REVIEW

Zinc Oxide Nanostructures for NO₂ Gas–Sensor Applications: A Review

Rajesh Kumar · O. Al-Dossary · Girish Kumar · Ahmad Umar

Received: 1 November 2014/Accepted: 20 November 2014/Published online: 16 December 2014 © The Author(s) 2014. This article is published with open access at Springerlink.com

Abstract Because of the interesting and multifunctional properties, recently, ZnO nanostructures are considered as excellent material for fabrication of highly sensitive and selective gas sensors. Thus, ZnO nanomaterials are widely used to fabricate efficient gas sensors for the detection of various hazardous and toxic gases. The presented review article is focusing on the recent developments of NO₂ gas sensors based on ZnO nanomaterials. The review presents the general introduction of some metal oxide nanomaterials for gas sensing application and finally focusing on the structure of ZnO and its gas sensing mechanisms. Basic gas sensing characteristics such as gas response, response time, recovery time, selectivity, detection limit, stability and recyclability, etc are also discussed in this article. Further, the utilization of various ZnO nanomaterials such as nanorods, nanowires, nano-micro flowers, quantum dots, thin films and nanosheets, etc for the fabrication of NO₂ gas sensors are also presented. Moreover, various factors such as NO₂ concentrations, annealing temperature, ZnO morphologies and particle sizes, relative humidity, operating temperatures which are affecting the NO₂ gas sensing properties are discussed in this review. Finally, the review article is concluded and future directions are presented.

Keywords ZnO nanostructure · Gas sensors · Sensor parameters · Sensor mechanism

1 Introduction

Tremendous increase in environmental pollution due to the fast industrialization, population growth, combustion of fuels

R. Kumar · G. Kumar PG Department of Chemistry, JCDAV College, Dasuya 144 205, Punjab, India

O. Al-Dossary

Department of Physics, King Saud University, Riyadh 11442, Kingdom of Saudi Arabia

A. Umar

Department of Chemistry, Faculty of Arts and Sciences, Najran University, P.O. Box 1988, Najran 11001, Kingdom of Saudi Arabia

A. Umar (🖂)

e-mail: ahmadumar786@gmail.com

from vehicles, use of pesticides and insecticides in agricultural sector, leakages of toxic chemical and gases is an alarming threat to ecosystems present in biosphere. The dissolution of harmful chemical from industrial effluent and runoff water from agricultural lands into running as well as underground water may result a number of health hazards. Early detection and monitoring of these poisonous and hazardous chemicals is thus required for environmental security purposes.

Chemical sensors play a significant role for the detection and monitoring of poisonous hazardous chemicals. Scientific community and researchers around the globe thus are trying to develop novel chemical sensors with superior performances. These chemical sensors also play other important and vital roles in other areas gas alarms, sensors for water and soil pollutants, human health, temperature sensor, speed sensor, magnetic field sensor, and emissions control [1, 2]. A sensor is a component of an electronic circuit which senses and undergoes physical and chemical changes on its surface due to the adsorption of a chemical stimulant. These adsorbed chemical species change the

Promising Centre for Sensors and Electronic Devices (PCSED), Najran University, P.O. Box 1988, Najran 11001, Kingdom of Saudi Arabia

electrical properties of the sensor and subsequently convert these changes into measurable quantities [3–5].

Long ago in 1938, Wagner et al. observed remarkable change in the electrical properties at high temperatures for semiconductor materials on exposure to reducing or oxidizing gases [6]. Based upon these facts, Seiyama et al. for the first time developed semiconductor-based detector for gaseous components [7]. It was observed that at high temperatures of 400 °C, the adsorption and desorption of analyte gases results in a comprehensive change in electrical conductivity and resistivity of semiconductor materials.

From the variety of gas sensors, semiconducting metal oxide sensors such as ZnO [8–11], SnO₂ [12–14], WO₃ [15–17], CuO [18–20], Fe₂O₃ [21], In₂O₃ [22–25], CdO [26], TeO₂ [27], and MoO₃ [28] have been extensively used. Recently, ZnO nanostructures with variety of morphologies including nanorods [29–41]; nanowires [42–44]; nanofibres [45]; nanolines [46]; nanobelts [47]; nanoneedles [48]; nanoprism [49]; nanotubes [50]; nano/microflowers [51, 52]; quantum dots [54–56]; nanoparticles [57–60]; nanofilms, sheets, and plates [61–63]; nano/microspheres [64]; nanopyramids [65]; and nanotetrapods [66] have been extensively studied and applied for gas sensing applications as these materials under operating conditions possess high electron mobility, non-toxic nature, high-specific surface area, good chemical, and thermal stability [67, 68].

This review article presents recent developments for the synthesis and fabrication of ZnO, the n-type semiconductorbased gas sensors with variable morphologies, gas sensing mechanism, electrode assemblies, factors influencing gas sensing behavior of ZnO nanostructures, applications of ZnO-based nanomaterials as gas sensors for oxidizing gas analyte specially NO₂ in this case and finally some draw-backs and limitations related to ZnO-based gas sensors.

2 Chemical Behavior of NO₂

 NO_2 is pungent red-brown oxidizing gas which enters the atmosphere from either natural sources or due to human activities. The latter are much more significant as they contribute reasonably a high NO_2 concentration into the atmosphere. A large amount of oxides of nitrogen are disposed into the atmosphere due to fossil fuel combustion in automobiles and industries everyday. NO_2 is regarded as a secondary pollutant produced from primary source NO which is being generated from internal combustion engines. In atmosphere, NO_2 absorbs light in the ultraviolet region below 398 nm resulting in its photo-dissociation.

$$NO_2 + hv(<398 \text{ nm}) \to NO + O \tag{1}$$

These reactive species are converted into HNO₃, organic, and inorganic nitrates including peroxyacetyl nitrate (PAN) through a series of chemical reaction (Eqs. 2–7).

$$NO + O_3 \rightarrow NO_2 + O_2 \tag{2}$$

$$NO_2 + O_3 \rightarrow NO_3 + O_2 \tag{3}$$

$$NO + NO_3 \rightarrow 2NO_2$$
 (4)

$$O + NO_2 \rightarrow NO + O_2$$
 (5)

$$NO_2 + NO_3 \rightarrow N_2O_5$$
 (6)

$$N_2O_5 + H_2O \rightarrow 2HNO_3$$
 (7)

Hydrocarbons in the atmosphere produce peroxyacyl group which by an addition reaction of with NO_2 produces PAN (Eq. 8).



Prolonged exposure to NO_2 can cause inflammation of lung tissue, bronchiolitis fibrosa obliterans, and silo-filler's disease. Exposure of plants to several ppm of NO_2 results in inadequate chlorophyll synthesis causing chlorosis and other plant tissue breakdowns. Still higher exposure can result in decreased rate of photosynthesis. Nitrogen dioxide also results in degradation of dyes and inks used in textile industries. NO_2 emitted by supersonic jets in atmosphere causes the destruction of ozone layer present in the stratosphere which absorbs the harmful damaging UV radiation coming from the sun.

3 Structure and Mechanism of ZnO for Gas Sensing Behavior

According to Yamazoe [69], there are two basic functions which a gas sensor consist of. These are receptor functions and transducer functions. Receptor function includes the recognition the chemical substance, whereas transducer function converts the chemical signal into electrical signals. This section deals with the structural properties favoring receptor functions of ZnO responsible for gas sensing behavior. ZnO has many different structural forms and shapes grown under different growth conditions. Wurtzite is the most favored form of ZnO at ambient conditions thermodynamically. The lattice constant parameters of wurtzite ZnO are a = 3.249 Å and c = 5.207 Å corresponding to *P63mc* space group with two interconnecting hexagonal-close-packed (hcp) sub-lattices in hexagonal lattice of Zn²⁺ and O²⁻ involving *sp*³ covalent bonding [70] (Fig. 1)

The ionic character of the material gives rise to a polar repeat unit along the *c*-axis. As a consequence of this polar symmetry, [0001] and $[000\overline{1}]$ surfaces of wurtzite ZnO



Fig. 1 a ZnO unit cell with wurtzite structure. b Various crystal planes of ZnO Wurtzite structure

exhibit different bulk terminations with the first one terminated by Zn-atoms and the latter by O-atoms. These are the most common crystal orientations of ZnO with different chemical and physical properties. As the repeating units of the crystal structure are perpendicular to the c-axis, a dipole moment exhibited the Madelung energy diverges at these surfaces for an ideal bulk truncation. This is a general property of 'polar surfaces' and consequently such bulktruncated surfaces cannot be stable. Despite this inherent instability, the polar [0001] and the $[000\overline{1}]$ surfaces are among the most common crystal orientations of ZnO. To stabilize these polar surfaces, additional positive or negative charges are required. This implies that there exist efficient stabilization mechanisms of these surfaces that allow a convergence of the Madelung energy (electrostatic potential). These stabilization mechanisms may also influence the gas sensing properties of ZnO [71–76]. ZnO is an n-type semiconductor with electrons as current carriers. The adsorption of molecular and atomic oxygen on the surface of ZnO nanoparticles creates an electron-depleted spacecharge layer, an important characteristic of the receptor function. This adsorbed oxygen further determines the surface charge layer thickness, surface potential barrier height, surface charge, and Debye length [77–79]. These parameters strongly affect the gas response and the selectivity of the ZnO gas sensors. The easy hydroxylation of the ZnO [0001] causes a metallization of the surface which can affect the conductivity response of such samples. The studies of the surface properties of the polar surfaces indicate that the differences in the chemical properties of the two polar surfaces affect the chemisorption of molecules and this plays an important role in gas sensing of such systems.

Han et al. [80] demonstrated that the gas sensing performance of ZnO is affected by its crystal defects. Greater the extent of oxygen vacancies higher is the gas response of ZnO [81]. In addition to this, the gas sensing performance of ZnO is also greatly found to be dependent on the size and morphology [82].

The second function, viz. transducer function, depends upon interactions of analyte gas and the ZnO nanoparticles. Two types of interactions are considered to be important which may be either grain-boundary or neck interactions. As far as the grain-boundary contacts are considered, the movement of the electrons occurs for each boundary across the surface potential barrier. As a result, the barrier height is altered and consequently the electric resistance of the sensor material is also changed [83]. However, the resistance and the gas response are independent of the particle size (Fig. 2a, b).

On the other hand for neck contacts, the transfer of the electron occurs through channels formed at each neck as a result of the space-charge layer. This channel width is controlled by the neck size; any change in the width alters the material resistance [59, 84] (Fig. 2c, d). With decreasing particle size, the sensor material is devoid of the mobile charge carriers and thus only the space-charge layer region dominates. The energy bands become flat throughout the interconnected particles. As a result, there is no significant barrier for intercrystallite charge transport. However, high-temperature sintering of the ZnO nanomaterials for making porous layers on different substrates results in agglomeration, thereby increasing grain size. Adsorbed NO₂ gas on the surface of the ZnO nanoparticles gets reduced by the transfer of the electrons from the conduction band (Fig. 3) of ZnO, thereby broadening the electron-depleted layer and hence resulting in wider junction potential barriers as shown in Fig. 2. This increases the resistance of the ZnO layer with widening of the junction potential barriers. This forms the basis of applications of ZnO nanomaterials as potential gas sensors. Exceptionally, Wang et al. [50] observed a p-type semiconductor behavior



Fig. 2 Schematic diagrams representing potential of **a**, **b** ZnO nanoparticles with grain-boundary junctions in the presence of dry air and NO₂ gas, respectively. **c**, **d** ZnO nanoparticles with necked junctions in the presence of dry air and NO₂ gas, respectively. Thickness of the *arrows* is related to the amount of electron current carriers. Reprinted with permission from [59]. © 2009 Elsevier B.V



Fig. 3 Schematic representation of receptor functions of ZnO gas sensor

for ZnO nanotubes at low operating temperature of 30-50 °C which switches over to n-type behavior at high temperature for NO₂ concentrations ranging between 500 ppb and 10 ppm.

4 Basic Gas Sensing Characteristics

In the literature, a number of gas sensing parameters such as gas response (*R*), response time (τ_{res}), recovery time (τ_{rec}), analyte concentration, operating temperature, and

detection limit for ZnO-based gas sensors are reported. These parameters are elaborated in this section.

4.1 Gas Response

Gas response of a gas sensor is generally defined as the ratio of the resistance change on the surface of the gas sensor before and after being exposed to the gas analyte. It is mathematically expressed in different forms by different group of researchers as shown in Eqs. 9 [35–38, 40, 41, 43, 47, 49, 50, 52, 54–62, 64, 65], 10 [29, 34, 39, 42, 44, 66], 11 [31, 48, 60, 63] and 12 [30, 53].

$$R = \frac{R_{\rm g}}{R_{\rm a}} \tag{9}$$

$$R = \frac{R_{\rm g} - R_{\rm a}}{R_{\rm a}} = \frac{\Delta R}{R_{\rm a}} \tag{10}$$

$$R = \frac{R_{\rm g} - R_{\rm a}}{R_{\rm a}} \times 100 = \frac{\Delta R}{R_{\rm a}} \times 100 \tag{11}$$

$$R = \frac{I_0 - I_g}{I_g} = \frac{\Delta I}{I_g},\tag{12}$$

where R_a is the sensor resistance in presence of ambient dry air and R_g the sensor resistance in the presence of target gas; I_0 the reference value (baseline) of the ZnO nanomaterials in dry air ambient and I_g the current of the ZnO nanomaterials in the presence of target gas.

4.2 Response Time

Response time, is the time taken by a gas sensor upon exposure to a target gas from the first reaction to the stable end value when the signal has reached a particular percentage level (in general taken as 90 % in many reports and is usually represented as T_{90}) [13–36, 38–45]. Further, lower the response time better are the sensing properties of the sensor. The response time is short for higher concentrations of target gases. Therefore, care should be taken for monitoring toxic gases at low concentrations as they may take a longer response time. In ZnO-based gas sensor, typical response time may be of the order of a minute or less. Other parameters which may affect the response time are NO₂ flow rate, temperature, and pressure of the analyte gas.

4.3 Recovery Time

Recovery time is the time required by a sensor so as to return to 90 % of the original baseline signal when the target gas is removed and the sensor is subsequently cleaned with dry air [29-34]. For good sensor applications, sensor recovery time should be small so that the sensor can be used over and over again.

4.4 Selectivity

In general, the selectivity of a gas sensor material means the preferential chemiresistive sensing for a particular gas in the presence of another gas under similar operating conditions. The selectivity of ZnO-based nanosensors can be expressed as in Eq. 13 [63].

Selectivity

$$= \frac{\text{Sensitivity of the sensor toward interface gas } (S_i)}{\text{Sensitivity of the sensor toward target gas } (S_g)}$$
(13)

The ZnO film used as sensor by Chougule et al. [63] showed high selectivity for NO₂ over H₂S compared to NH₃.

4.5 Detection Limit

For high-performance sensor applications, sensor should be capable to detect even very low concentrations of the gases. The minimum concentration of analyte gas which can be detected by a sensor under operative conditions is called its lower detection limit [29–31]. For ZnO nanorod-based gas sensors, the lowest detection limit of 50 ppb at

300 °C [29], 10 ppb at 250 °C [30], and 100 ppb at 250 °C [31] has been reported for NO₂ gas.

4.6 Stability and Recyclability

Stability of the sensor material refers to its ability to maintain its sensing properties repeatedly and even for long durations. ZnO sensor exhibits relatively high response which drops with time due to interface modification during operation to a steady state [63].

All these parameters depend on the nature, particle size and morphology of the sensing material, the type of interactions and reactions occurring between the gas and the sensor material, the sensor operating conditions, etc. In order to control these parameters, scientific understanding of gas–sensor interaction and various new technological concepts and novel materials have been developed, and some of these issues will be discussed in the latter sections.

5 Zinc Oxide Nanostructure-Based NO₂ Gas Sensors: Synthesis, Growth, and Characterization

Intense research efforts to synthesize ZnO nanomaterials and to fabricate efficient miniaturized devices using these materials for the applications in various nano-electronics and nanosensors are on a go around the globe. For this, a variety of fabrication techniques and methods have been explored in the literature for the synthesis of zinc oxide nanostructures. Varieties of morphologies for ZnO have been synthesized using various physical and chemical methods explained in the next section.

5.1 1-D ZnO Nanomaterials (Nanorods, Nanowires, Nanotubes, and Nanofibres)

The 1-D ZnO nanostructures, for instance nanorods, nanotubes, nanowires, and nanofibres, have been extensively studied for gas sensing applications due to their high surface-volume ratio, crystallinity, and charge confinement ability. A number of methods are reported in literature for the fabrication of 1-D ZnO nanostructures for gas sensors. Quantity and quality of 1-D ZnO nanostructures, however, vary widely from process to process. These synthetic processes can be broadly classified into two categories like (a) wet processing routes including hydrothermal methods, sonochemical growths, chemical bath depositions, etc. These methods may or may not involve the use of capping agents, (b) vapor-phase processing routes which include various sputtering techniques, thermal evaporation, and vapor-phase transport. For the growth of 1-D ZnO nanostructures, processing details are summarized in Table 1.

Growth reagentsSubstrateAnne.Anne.Particle size $Zn(NO)_2 6H_0$ (HMTA)Glass 500 2Particle size $Zn(NO)_2 6H_0$, HMTAHumina $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, MUTAHumina $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, KClProus silicon $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, KOH $=$ $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, KOH $=$ $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, CTAB $=$ $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, CTAB $=$ $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, CTAB $=$ $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, CTAB $=$ $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, CTAB $=$ $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, CTAB $=$ $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, CTAB $=$ $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, CTAB $=$ $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, CTAB $=$ $=$ $=$ $=$ $=$ $Zn(NO)_2 6H_0$, CTAB	Table 1 1D-ZnO nanostructu	res: morphology, methods of pre	Table 1 1D-ZnO nanostructures: morphology, methods of preparation, size, and other growth parameters	barameters					
icrop.icro	Morphology	Synthetic method	Growth reagents	Substrate	Anne.	Anne.	Particle size		Ref.
Hydrothermal method $Zq(XO)_{2}(H,YI,TA)$ Ginss500239-10Bydrothermal method $Zu(XO)_{2}(H,YI,TA)$ Alumina $-$ 00Bydrothermal method $Zu(XO)_{2}(H,YI,TA)$ Alumina $-$ 00Hydrothermal method $Zu(C)_{2}(H,YI,TA)$ Prous silicon $-$ 2200Hydrothermal method $Zu(Y_{2},Y_{2},TA)$ Prous silicon $ -$ 200University $Zu(Y_{2},Y_{2},TA)$ $ -$ 2200Hydrothermal method $Zu(Y_{2},Y_{2},TA)$ $ -$ unovoidsHydrothermal method $Zu(Y_{2},Y_{2},TA)$ $ -$ unovoidsHydrothermal method $Zu(Y_{2},Y_{2},TA)$ $ -$ unovoidsHydrothermal method $Zu(Y_{2},Y_{2},TA)$ $ -$ unovoidsHydrothermal method $Zu(Y_{2},Y_{2},TA)$ $ -$ unovoidsHydrothermal method $Zu(Y_{2},Y_{2},TA)$ $ -$					temp. (°C)	tıme (ın h)	Diameter (nm)	Length (nm)	
Bydrothermal method Za(NO) ₂ , 6H,0, H/TA Alumina - 100 Hydrothermal method Za(NO) ₂ , 6H,0, H/TA TIO could glass - - 100 Hydrothermal method Za(NO) ₂ , 6H,0, H/TA TIO could glass - - 50 Hydrothermal method Za(NO) ₂ , 6H,0, KCI Porous silicon - 200 Hydrothermal method Za(Y) ₂ , H/TA Procus silicon - 200 Hydrothermal method Za(Y) ₂ , H/TA Procus silicon - 200 Hydrothermal method Za(Y, PI) Procus silicon - 200 Mininay Za(Y, PI) Procus silicon - 200 Hydrothermal method Za(Y, PI) - - 200 Mininay Za(Y, PI) - - - 200 Mininay Za(Y, PI) Procus silicon - - 200 Mininay Za(Y, PI) Za(Y, PI) - - - 200 Mininay Procus silicon Za(Y, PI)	Nanorods	Hydrothermal method	Zn(NO ₃) ₂ ·6H ₂ O, (HMTA)	Glass	500	2	30-120	250	[29]
Sonobenical method $Zn(N_0)_2.6H_20$, MTrATrO conted glass $ 30$ Hythohermal method $Zn(H_2CO)_2.2H_20$, Alumina $ 33$ Hythohermal method $Zn(C)_2.6H_20$, KC1Pavous silicon $ 33$ Hythohermal method $Zn(C)_2.6H_20$, KC1Pavous silicon $ 200$ Hythohermal method $ 200$ Hythohermal method $ 200$ Hythohermal method $ -$ Gontinuous hythohermal $Zn(N_0)_2.6H_20$, KOH $ -$ Muotohermal method $Zn(N_0)_2.6H_20$, KOH $ -$ Muotohermal method $Zn(N_0)_2.6H_20$, KOH $ -$ Muotohermal method $Zn(N_0)_2.6H_20$, KOH $ -$ Muotohermal method $Zn(N_0)_2.6H_20$, CTAB $ -$ Muotohermal method $Zn(N_0)_2.6H_20$, CTAB $ -$ Muotohermal method $Zn(N_0)_2.6H_20$, CTAB $ -$ <td< td=""><td>Nanorods</td><td>Hydrothermal method</td><td>$Zn(NO_3)_2.6H_2O$, HMTA</td><td>Alumina</td><td>I</td><td>I</td><td>100</td><td>1.62 µm</td><td>[30]</td></td<>	Nanorods	Hydrothermal method	$Zn(NO_3)_2.6H_2O$, HMTA	Alumina	I	I	100	1.62 µm	[30]
Hydrothermal method different growth different growth different growth different growth different growth different growth 	Nanorods	Sonochemical method	Zn(NO ₃) ₂ .6H ₂ O, HMTA	ITO coated glass	I	I	50	500	[31]
Electrochemical deposition $ZnCl_3, KCl$ Provos silicon $ 200$ Hydrothermal method $ 200$ Continuous hydrothermal $Zn(N_0)_2 6H_2O, KOH$ $ 0$ Gontinuous hydrothermal method $Zn(N_0)_2 6H_2O, KOH$ $ 0$ Muso synthesis $Zn(N_0)_2 6H_2O, KOH$ $ 0$ morotidsHydrothermal method $Zn(N_0)_2 6H_2O, CTAB$ $ -$ adsHydrothermal method $Zn(N_0)_2 6H_2O, CTAB$ $ -$ adsHydrothermal method $Zn(N_0)_2 6H_2O, CTAB$ $ -$ adsHydrothermal method $Zn(N_0)_2 6H_2O, CTAB$ $ -$ adsHydrothermal method $Zn(N_0)_2 6H_2O, CTAB$ A_1_2O $ -$ adsHydrothermal method $Zn(N_0)_2 6H_2O, CTAB$ A_1_2O $ -$ adsHydrothermal $Zn(N_0)_2 6H_2O, CTAB -adsHydrothermalZn(N_0)_2 6H_2O, CTAB -adsCTAB-assisted hydrothermalZn(N_0)_2 6H_2O, CTAB -$	Nanorods	Hydrothermal method (different growth temperatures)	Zn(CH ₃ COO) ₂ ·2H ₂ O, diaminopropane, (HMTA)	Alumina	1	I	33	1.00 μm (90 °C) 1.43 μm (100 °C)	[32]
Electrochemical deposition $Zn(J_2, KCl)$ Prons slicon $ 2$ 200 Hydrothermal method $ 200$ Bydrothermal method $ -$ Continuous hydrothermal method $Zn(N_2)_2 6H_2 0, KOH$ $ -$ Bydrothermal method $Zn(N_2)_2 6H_2 0, CTAB -noclustersChemical bath depositionZn(N_2)_2 6H_2 0, CTAB -noclustersChemical bath depositionZn(N_2)_2 6H_2 0, CTAB -noclustersChemical bath depositionZn(N_2)_2 6H_2 0, CTAB -ondsReverse microemulsionZn(N_2)_2 6H_2 0, CTABA_12 0, A_2 0, A$								1.78 μm (110 °C)	
Hydrothermal method10Rydrothermal method $Zn(NO_{3}; 6H_{2}O, KOH$ 0RunovoidsHydrothermal method $Zn(NO_{3}; 6H_{2}O, KOH$ RunovoidsHydrothermal method $Zn(S_{1}; P123$ 500823odsHydrothermal method $Zn(NO_{3}; 6H_{2}O, CTAB$ -5001100-150unoclustersChemical bath deposition $Zn(CH_{3}COO)_{2}: 2H_{2}O, Quartz500211odsHydrothermal methodZn(NO_{3}; 6H_{2}O, (HNTA)A_{1}O_{3}3001odsReverse microemulsionZn(CH_{3}COO)_{2}: 6H_{3}O, (HNTA)A_{1}O_{3}3001orodsReverse microemulsionZn(N_{2})_{2}: 6H_{3}O, (HNTA)A_{1}O_{3}3001orodsCTAB-assisted hydrothermalZn(N_{2})_{2}: 6H_{3}O, CTABA_{1}O_{3}3001orodsCTAB-assisted hydrothermalZn(N_{2})_{2}: 6H_{3}O, CTABorodsCTAB-assisted hydrothermalZn(N_{2})_{2}: 6H_{3}O, CTABorodsCTAB-assisted hydrothermalZn(N_{2})_{2}: 6H_{3}O, CTAB$	Nanorods	Electrochemical deposition	ZnCl ₂ , KCl	Porous silicon	I	I	200	700	[33]
Hydrothermal method10Continuous hydrothermalZn(No.) ₂ .6H ₂ O. KOH10flow synthesisHydrothermal methodZn(No.) ₂ .6H ₂ O. KOH10odsHydrothermal methodZn(No.) ₂ .6H ₂ O. KTAB-500823odsHydrothermal methodZn(No.) ₂ .6H ₂ O. CTAB-6001100-150motolustersChemical bath depositionZn(No.) ₂ .6H ₂ O. CTAB-6001100-150an 1-Dchemical bath depositionZn(CH ₃ COD) ₂ .2H ₂ O.Quartz500823adsHydrothermal methodZn(No.) ₂ .6H ₂ O. (HMTA)Al ₂ O.33001adsHydrothermalZn(No.) ₂ .6H ₂ O. (HMTA)Al ₂ O.33001adsHydrothermalZn(No.) ₂ .6H ₂ O. (TABAl ₂ O.33001adsHydrothermalZn(No.) ₂ .6H ₂ O. (TABAl ₂ O.33001adsHydrothermalZn(No.) ₂ .6H ₂ O. CTABAl ₂ O.33001adsPEG-assisted hydrothermalZn(No.) ₂ .6H ₂ O. CTAB20000adsPEG-assisted hydrothermalZn(No.) ₂ .6H ₂ O. CTAB20adsPEG-assisted hydrothermalZn(No.) ₂ .6H ₂ O. CTAB2020adsPEG-assisted hydrothermal <td>Nanosheets</td> <td></td> <td></td> <td></td> <td></td> <td></td> <td></td> <td></td> <td></td>	Nanosheets								
	Nanorods	Hydrothermal method	1	I	I	I	10	Several tens of nm length	[34]
nanovidsHydrothermal methodZnCl3, P123-500823odsHydrothermal methodZn(NO_3)26H2O, CTAB-6001100-150nn 1-DChemical bath depositionZn(NO_3)26H2O, CTAB-6001100-150odsHydrothermal methodZn(NO_3)26H2O, CTAB-6001100-150odsHydrothermal methodZn(NO_3)26H2O, CTABAl2O330021 µmonodsReverse microemulsionZn(NO_3)26H2O, HMTA)Al2O33001norodsReverse microemulsionZn(NO_3)26H2O, CTABAl2O33001norodsCTAB-assisted hydrothermalZn(NO_3)26H2O, CTABAl2O330049090norodsCTAB-assisted hydrothermalZn(NO_3)26H2O, CTAB400, 600, 49090norodsCTAB-assisted hydrothermalZn(NO_3)26H2O, CTAB9090norodsCTAB-assisted hydrothermalZn(NO_3)26H2O, CTAB9090norodsCTAB-assisted hydrothermalZn(NO_3)26H2O, CTAB909090norodsCTAB-assisted hydrothermalZn(NO_3)26H2O, CTAB909090norodsCTAB-assisted hydrothermalZn(NO_3)26H2O, CTAB209090norodsCTAB-assisted hydrothermalZn(NO_3)26H2O, CTAB<	Nanorods Nanoprisms	Continuous hydrothermal flow synthesis	Zn(NO ₃) ₂ .6H ₂ O, KOH	I	I	I	I	I	[35]
odsHydrothermal method $Zn(N\tilde{O}_3)_2 6H_2 O, CTAB$ -6001100-150nn LDnn clustersChemical bath deposition $Zn(N\tilde{O}_3)_2 6H_2 O, CTAB$ -6001100-150adsHydrothermal method $Zn(NO_3)_2 6H_2 O, (HMTA)$ $A_{12}O_3$ 300 1adsHydrothermal method $Zn(NO_3)_2 6H_2 O, (HMTA)$ $A_{12}O_3$ 300 1norodsReverse microemulsion $Zn(N_3)_2 6H_2 O, CTAB$ $A_{12}O_3$ 300 1norodsCTAB-assisted hydrothermal $Zn(NO_3)_2 6H_2 O, CTAB$ $A_{10}G_0 O, 4$ 52 8000 800 800 $400, 600, 4$ 90 norodsCTAB-assisted hydrothermal $Zn(NO_3)_2 6H_2 O, CTAB$ $ 400, 600, 4$ 90 800 90 800 90 800 90 800 90 <	Nanorods with nanovoids	Hydrothermal method	ZnCl ₂ , P123	1	500	8	23	006	[36]
moclustersChemical bath deposition $Zn(CH_3COO)_2·2H_0$. ethaholamineQuartz 500 2 $1 \ \mum$ onI-D $Zn(NO_3)_2·6H_3O$. (HMTA) AI_2O_3 300 1 $-$ odsHydrothermal method $Zn(NO_3)_2·6H_3O$. (HMTA) AI_2O_3 300 1 $-$ norodsReverse microemulsion $Zn(NO_3)_2·6H_3O$. (TAB-assisted hydrothermal $Zn(NO_3)_2·6H_2O$. $Zn(N_3)_2·6H_2O$. AI_2O_3 300 1 $-$ norodsCTAB-assisted hydrothermal $Zn(NO_3)_2·6H_2O$. $Zn(NO_3)_2·6H_2O$. 200 400 , 600 4 52 norodsPEG-assisted hydrothermal $Zn(NO_3)_2·6H_2O$. $Zn(NO_3)_2·6H_2O$. 200 4 52 norodsCTAB-assisted hydrothermal $Zn(NO_3)_2·6H_2O$. $Zn(NO_3)_2·6H_2O$. 200 4 52 norodsCTAB-assisted hydrothermal $Zn(NO_3)_2·6H_2O$. $Zn(NO_3)_2·6H_2O$. 2 200 4 52 norodsCTAB-assisted hydrothermal $Zn(NO_3)_2·6H_2O$. $Zn(NO_3)_2·6H_2O$. 200 4 52 norodsCTAB-assisted hydrothermal $Zn(NO_3)_2·6H_2O$. $Zn(NO_3)_2·6H_2O$. $ZnO_2O_2O_2O_2O_2O_2O_2O_2O_2O_2O_2O_2O_2O$	Au/ZnO nanorods	Hydrothermal method	Zn(NO ₃) ₂ ·6H ₂ O, CTAB	I	600	1	100-150	1–1.5 μm,	[37]
Chemical bath deposition $Zn(CH_3COO)_2\cdot 2H_2O$, ethaholamineQuartz 500 21 µmHydrothermal method $Zn(NO_3)_3\cdot 6H_2O$, (HMTA) A_2O_3 300 1 $-$ Reverse microemulsion $Zn(NO_3)_3\cdot 6H_2O$, (HMTA) A_2O_3 300 1 $-$ Reverse microemulsion $Zn(CH_3COO)_2, SDS$ $ 400, 600$, 4 52 Reverse microemulsion $Zn(NO_3)_2\cdot 6H_3O$, CTAB $ 400, 600$, 4 52 PEG-assisted hydrothermal $Zn(NO_3)_2\cdot 6H_3O$, CTAB $ 400, 600$, 4 52 Vapor-phase growth $Zn(NO_3)_2\cdot 6H_3O$, CTAB $ -$ Vapor-phase growth ZnO/C Si sapphire $ -$ Carbothermal reduction ZnO/C $Si (Saphire -Carbothermal reductionZnO/CSi (Saphire -Uspor-phase growthPure ZnSi (Saphire -Carbothermal reductionZnO/CSi (Saphire -$	ZnO nanorods								
Hydrothermal method $Zn(NO_3)_2.6H_2O$, $Ce(NO_3)_3.6H_2O$, $(HMTA)$ Al_2O_3 300 1-Reverse microemulsion $Zn(CH_3COO)_2$, SDS- $400, 600$, 800 452Reverse dydrothermal $Zn(NO_3)_2.6H_2O$, CTAB $400, 600$, 800 452PEG-assisted hydrothermal $Zn(NO_3)_2.6H_2O$, CTAB $400, 600$, 800 452Vapor-phase growth $Zn(NO_3)_2.6H_2O$, CTAB-20Vapor-phase growth $Zn(NO_3)_2.6H_2O$, CTAB20Vapor-phase growth ZnO/C Si sapphire20Vapor-phase growth ZnO/C Si O_3/Si 80-120Vapor-phase growthPure Zn SiO_3/Si 80-120Carbothermal followed by ZnO/C SiO_3/Si 20Carbothermal reduction ZnO/C SiO_3/Si 20Vapor-phase growthPure Zn Al_2O_3 20Carbothermal reduction ZnO/C SiO_3/Si 20Vapor-phase growthPure Zn Al_2O_3 20Carbothermal reduction ZnO/C SiO_3/Si 20Vapor-phase growthPure Zn Al_2O_3 Carbothermal reduction ZnO/C SiO_3/Si	Hierarchical nanoclusters were built from 1-D nanorods	Chemical bath deposition	Zn(CH ₃ COO) ₂ ·2H ₂ O, ethaholamine	Quartz	500	7	1 µm	2.5 µm	[38]
Reverse microemulsion $Zn(H_3COO)_2$, SDS-400, 600, 452CTAB-assisted hydrothermal $Zn(NO_3)_26H_2O$, CTAB 800 490PEG-assisted hydrothermal $Zn(CH_3COO)_2$, PEG 800 452Vapor-phase growth $Zn(NO_3)_26H_2O$, CTAB20Vapor-phase growth ZnO/C Si sapphire-20Carbothermal reduction ZnO/C SiO_2/Si 20Vapor-phase growth ZnO/C SiO_2/Si 20Vapor-phase growth ZnO/C SiO_2/Si 20Carbothermal reduction ZnO/C SiO_2/Si 0Vapor-phase growthPure Zn SiO_2/Si 0Carbothermal reduction ZnO/C SiO_2/Si 00Carbothermal reduction ZnO/C SiO_2/Si 20Carbothermal reduction ZnO/C SiO_2/Si 00Carbothermal reduction ZnO/C SiO_2/Si 0Carbothermal reduction ZnO/C SiO_2/Si 00Carbothermal reduction ZnO/C SiO_2/Si 0Carbothermal reduction ZnO/C ZnO/C SiO_2/Si 0Carbothermal reduction ZnO/C ZnO/C ZnO/C ZnO/C ZnO/C ZnO/C	Ce/ZnO nanorods	Hydrothermal method	Zn(NO ₃) ₂ ·6H ₂ O, Ce(NO ₃) ₃ ·6H ₂ O, (HMTA)	Al_2O_3	300	1	I	915–1,915 nm	[39]
CTAB-assisted hydrothermal $Zn(NO_3)_2\cdot 6H_2O, CTAB$ $400, 600, 4$ 90PEG-assisted hydrothermal $Zn(CH_3COO)_2, PEG$ 600 4 52 Vapor-phase growth $Zn(NO_3)_2\cdot 6H_2O, CTAB$ $ 20$ Vapor-phase growth ZnO/C Si sapphire $ 20$ Vapor-phase growth ZnO/C $Si sapphire$ $ 20$ Vapor-phase growth ZnO/C $Si O_2/Si$ $ 20$ Vapor-phase growth ZnO/C SiO_2/Si $ 80-120$ Vapor-phase growthPure Zn Al_2O_3 $ -$ Use on the end of the end o	Needle-like nanorods	Reverse microemulsion	Zn(CH ₃ COO) ₂ , SDS	1	400, 600, 800		52	3 µm	[40]
PEG-assisted hydrothermalZn(CH_3COO)_2, PEG600452CTAB-assisted hydrothermalZn(NO_3)_26H_2O, CTAB20Vapor-phase growthZnO/CSi sapphire20Vapor-phase growthZnO/CSi Sapphire20Carbothermal reductionZnO/CSiO_2/Si80-120Vapor-phase growthPure Zn Al_2O_3 50Electrospinning followed byZn(CH_3COO)_2·2H_2O, HMTA140-210chemical bath denositionCarbothermal140-210	Pencil-like nanorods	CTAB-assisted hydrothermal	Zn(NO ₃) ₂ ·6H ₂ O, CTAB		400, 600, 800		90	4 µm	
CTAB-assisted hydrothermalZn(NO_3)_2·6H_2O, CTAB20Vapor-phase growthZnO/CSi sapphire20Vapor-phase growthZnO/CSi sapphire20Carbothermal reductionZnO/CSiO_2/Si80–120Vapor-phase growthPure ZnAl_2O_350Electrospinning followed byZn(CH_3COO)_2·2H_2O, HMTA140–210chemical bath denositionCarbothermal140–210	Flower-like nanorods	PEG-assisted hydrothermal	$Zn(CH_3COO)_2$, PEG		600	4	52	3 µm	
Vapor-phase growthZnO/CSi sapphireMean diameter ofCarbothermal reductionZnO/CSiO ₂ /Si80–120Vapor-phase growthPure ZnAl ₂ O ₃ 80–120User Compared byZn(CH ₃ COO) ₂ ·2H ₂ O, HMTA50Chemical bath denositionChanol and denosition140–210	Pencil-like nanorods	CTAB-assisted hydrothermal	$Zn(NO_3)_2.6H_2O, CTAB$	I	I	I	20	3–5 µm	[41]
Carbothermal reduction ZnO/C SiO ₂ /Si – – 80–120 Vapor-phase growth Pure Zn Al ₂ O ₃ – – 80–120 Electrospinning followed by Zn(CH ₃ COO) ₂ ·2H ₂ O, HMTA – – – 140–210 chemical bath deposition	Unbranched nanowires Branched* nanowires	Vapor-phase growth	ZnO/C	Si sapphire	I	I	Mean diameter of few nm	Lengths of few μm	[42]
Vapor-phase growthPure ZnAl2O350Electrospinning followed byZn(CH3COO)2·2H2O, HMTA140-210chemical bath deposition	Nanowires	Carbothermal reduction	ZnO/C	SiO ₂ /Si	I	I	80-120	10 µm	[43]
Electrospinning followed by Zn(CH ₃ COO) ₂ ·2H ₂ O, HMTA – – – – – 140–210 chemical bath deposition	Functionalized nanowires	Vapor-phase growth	Pure Zn	Al_2O_3	I	I	50	5-10 µm	[44]
	Nanobarbed fibers	Electrospinning followed by chemical bath deposition	Zn(CH ₃ COO) ₂ ·2H ₂ O, HMTA	I	I	I	140–210	175-850	[45]

Table 1 continued								
Morphology	Synthetic method	Growth reagents	Substrate	Anne.	Anne.	Particle size		Ref.
				temp. (°C)	time (in h)	Diameter (nm)	Length (nm)	
Nanolines	Sol-gel method	Zn(CH ₃ COO) ₂ ·2H ₂ O, 2-methoxyethanol and ethanol amine	1	700	-	Nanoline gap between 100 and 400 nm	1	[46]
Nanobelt	RF sputtering	ZnO	Sapphire	I	I	10	50	[47]
Nanoneedles Cacti-like structure	Low-temperature hydrothermal process	Zn(CH ₃ COO) ₂ ·2H ₂ O, diaminopropane, HMTA	Glass	I	I	15	300	[48]
Nanoprisms Nanofibers	Sol-gel method Electrospinning methods	Zn(CH ₃ COO) ₂ ·2H ₂ O, poly vinyl alcohol	Al ₂ O ₃	700 400, 700	I	25	100-500	[49]
Nanotubes	Hydrothermal method	ZnCl ₂ , methenamine	Silicon (100) wafer with a thin SiO ₂	400	9	200	I	[50]

Ozturk et al. [29] fabricated ZnO nanorods by hydrothermal method using $Zn(NO_3)_2 \cdot 6H_2O$ and hexamethylenetetramine (HMTA) precursors in equimolar ratios on seed layer. Seed layers were grown on glass substrate by sol–gel deposition method. Product obtained was annealed in air at 500 °C for 2 h. The dimensions of the as-synthesized nanorods were controlled by the different concentration of the precursors. With increasing concentration, the diameter was increased, whereas the length of the nanorods was almost constant (Fig. 4). It was observed that if equimolar mixtures of ZnO and HMTA were not used, no formation of ZnO nanorods was observed.

Increase in diameter can be attributed to wurtzite hexagonal crystal structures of ZnO with active polar faces [0001], $[000\overline{1}]$ and stable non-polar faces $[01\overline{1}0]$, $[0\overline{1}10]$, $[1\overline{1}00]$, $[\overline{1}100]$, $[\overline{1}010]$, $[10\overline{1}0]$. The latter is responsible for the radial growth of ZnO nanorods (Fig. 1).

Sahin et al. [30] used Zn(NO₃)₂·6H₂O and HMTA precursors for the synthesis of unannealed ZnO nanorods of diameter 100 nm and the length was 1.62 µm from ZnO thin film seed layer coated with indium tin oxide (ITO) glass substrate by hydrothermal method. Using same precursors, Oh et al. [31] sonochemical grew high-density ZnO nanorod arrays on Pt-electrode patterned alumina substrate. Liu et al. [32] prepared ZnO nanorods of 30 nm diameter and 1.78 µm length for seeded growth using equal molar ratio of zinc acetate dehydrate and HMTA on sputtered platinum interdigitated circuits over alumina plates as electrodes. The length of the nanorods was found to increase from 1.00 to 1.78 µm as the growth temperature was increased from 90 to 110 °C, whereas the diameter on the nanorods was found 33 nm for each growth temperature (Fig. 5). The observation is quite different from the effect of concentration of the precursors which results in radial growth increasing diameter without affecting the length of the nanorods. From this, it can be concluded that concentration of the precursors controls the radial growth along non-polar faces[0110], [0110], [1100], [1100][1010], [1010], while temperature has marked influence on active polar faces [0001], $[000\overline{1}]$ of the hexagonal wurtzite crystal structures of ZnO (Fig. 1).

In addition to the concentration and the temperature, the morphology and size of the ZnO nanomaterials is also affected by the pH of the solution. In this direction, Yan et al. [33] studied the effect of pH for electrochemically deposited ZnO at 65 °C using ZnCl₂ and KCl and a three-electrode glass electrochemical cell constituting Pt working electrode, counter electrode, and SCE electrode as reference electrode. At electrolyte pH = 6, dense zinc oxide nanosheets were formed on the porous silicon wafer substrate. When the pH of the electrolyte was increased to 6.5, ZnO nanosheets and nanorods arrays were formed on the surface of the porous silicon. Dendritic structures of ZnO were



Fig. 4 SEM images of ZnO nanorods for equimolar zinc nitrate and HMTA solution, a 0.001 M, b 0.01 M, c 0.1 M. Reprinted with permission from [29]. © 2013 Elsevier B.V

formed at still higher pH of 7. Thus, the presence of OH⁻ left in the solution plays a key role in the ZnO morphology. It must be due to the fact that ZnO is a polar crystal having positive polar [0001] plane comprising Zn^{2+} cations and a negative polar [0001] plane rich in O²⁻ anions. Anionic $[Zn(OH)_4]^{2-}$ complex formed as a result of reaction between Zn^{2+} and OH⁻ is preferably adsorbed on the positive polar [0001] plane of hexagonal ZnO nuclei. This leads to intrinsic anisotropy growth along the *c*-axis direction of the ZnO (Fig. 1) thereby resulting 1D nanostructures of ZnO such as nanorods formation at higher pH.

Shi et al. [35] studied the effect of volume ratios of H_2O_2 to zinc nitrate hexahydrate as precursors. The presence of H_2O_2 promotes faster growth along the [0001] direction by increasing the solubility of Zn^{2+} species in solution. At higher $[H_2O_2]$ to [Zn] ratio, the tapering of one end of the ZnO nanorods along the [0001] direction may be attributed to the suppression of the [0002] plane. The fact is supported by the XRD patterns for the ZnO samples formed (Fig. 6). At still higher $[H_2O_2]$ to [Zn] ratios, a tapered nanopyramid-like structures with sharp [0001] basal plane and a $[01\overline{1}1]$ radial plane are formed (Fig. 7).

Han et al. [36] synthesized single-crystal ZnO nanorods with nanovoids via a simple hydrothermal method for fabricating NO₂ gas nanosensors.

Deposition time is yet another key factor in determining the morphology of the nanostructures. Figure 8 represents the schematic representation of the growth mechanism for 1-D ZnO nanomaterials grown by Xu et al. [38] from ZnO thin film on quartz substrates.

It can be observed that with increase in deposition time the growth of ZnO nanorods along the [0001] direction, perpendicular to hexagonal basal planes, is enhanced. A lower concentration of Zn²⁺ from a critical value results in no nucleation and as a result, the size of nanoclusters formed is smaller. Chang et al. [39] compare the effect of growth time on the structure and morphology of Ce-doped ZnO nanorods. Increasing the growth time from 2 to 4 h and then to 24 h, the lengths of the highly uniform hexagonal ZnO nanorods were 915, 955, and 1,915 nm, respectively with the diameter range from 97nm to137 nm (Fig. 9). This may be attributed to the growth along nonpolar faces $[01\overline{10}], [0\overline{110}], [1\overline{100}], [1\overline{100}], [10\overline{10}]$ as well as along the active polar faces $[0001], [000\overline{1}]$ of the



Fig. 5 SEM micrographs of ZnO nanorod grown at a 90 °C, top view; b 90 °C, side view; c 100 °C, top view; d 100 °C, side view; e 110 °C, top view; f 110 °C, side view. Reprinted with permission from [32]. 0 2009 Taiwan Institute of Chemical Engineers published by Elsevier B.V

hexagonal wurtzite crystal structures of ZnO with growth time [85].

The morphology and dimensions of ZnO nanorods can also be controlled by the type of additives, their nature and base molar ratio ($OH^{-}:Zn^{2+}$), etc. Pencil-like ZnO nanorods and needle-like ZnO nanorods were synthesized by the cetyltrimethyl ammonium bromide (CTAB)-assisted hydrothermal process at low temperature and via reserve microemulsion method, respectively, whereas the flowerlike ZnO nanorods were fabricated by the polyethylene glycol (PEG)-assisted hydrothermal process by Bai et al. [40, 41]. Ionic surfactant like CTAB directs the growth and prevents the agglomeration for the anisotropic growth of 1D crystalline nanorods, with high crystallinity and high



Fig. 6 XRD patterns of ZnO nanopowder with 0, 0.05, 0.1, 0.15, and 0.25 $[H_2O_2]$ to [Zn] ratios, respectively. Reprinted with permission from [35]. © 2013 American Chemical Society



Fig. 7 Proposed growth directions for ZnO rods and pyramids with increasing $[H_2O_2]$ to [Zn] ratios, respectively. Reprinted with permission from [35]. © 2013 American Chemical Society

aspect ratio. $[Zn(OH)_4]^{2-}$ growth units generated for ZnO crystal during hydrothermal process are believed to be transported by CTAB to the polar [0001] plane resulting in the elongation of ZnO nanorods [41]. The optimized base molar ratio (OH⁻:Zn²⁺) of 6:1 was found to be appropriate for high-quality ZnO nanorods growth.

1-D ZnO nanowires have also been reported in the literature as efficient chemical and biological sensors. Seeded growth approach was adopted by An et al. [42] for the fabrication of branched ZnO nanowires in a three-step process. Unbranched ZnO nanowires initially grown on C-plane sapphire substrates were coated with a thin film of Au catalyst by direct current (DC) magnetron sputtering followed by thermal evaporation process. Figure 10a and b presents FESEM image of the as-synthesized branched ZnO 1-D dendrite-like nanowires having branches with diameter of few tens of nanometers and lengths of a few micrometers at low and high resolution, respectively, whereas Fig. 10c exhibits the morphology of the ZnO nanowires with globular Au particle which act as catalyst for secondary branch of a typical branched ZnO nanowire. Figure 10d reveals EDXS of the nanowires with an atomic weight ratio of O and Zn of 4:4. This indicates that the branched ZnO nanowires are highly rich in Zn contents.

Ahn et al. [43] fabricated ZnO nanowire for NO₂ gas sensing on patterned Au catalysts by a selective growth of nanowires using ZnO/C mixture. In another vapor-phase growth, Waclawik et al. [44] carried out uncatalyzed ZnO nanowire growth on alumina substrates using pure Zn powder as precursor. As grown ZnO Nanowires were further functionalized by tris(hydroxymethyl)aminomethane (THMA) and dodecanethiol (DT) for NO₂ gas detection. To study the NO₂ sensing behavior, Lee et al. [45] utilized electrospinning and chemical bath deposition methods for the synthesis of



Fig. 8 The SEM images and growth mechanism for ZnO nanostructures films deposited for various deposition time (5, 30, 60, and 90 min). Reprinted with permission from [38]. © 2012 Elsevier B.V



Fig. 9 Top-view FESEM images of Ce/ZnO nanorods at different growth times. $\mathbf{a} \ 2 \ h, \mathbf{c} \ 4 \ h$ and $\mathbf{c} \ 24 \ h$ and cross-sectional FESEM images at different growth times. $\mathbf{b} \ 2 \ h, \mathbf{d} \ 4 \ h$ and $\mathbf{f} \ 24 \ h$. Reprinted with permission from [39]. © 2014 Elsevier Ltd and Techna Group S.r.l

ZnO nanobarbed fibers by the epitaxial growth of 1-D ZnO nanorods on ZnO nanofibers. ZnO nanostructures with other variety of morphologies including nanolines [46] nanobelts [47], nanoneedles [48], and nanotubes [50] have also been reported in the literature and applied for NO₂ gas sensing.

5.2 ZnO Nano/Microflowers

There are many other ZnO nanostructures with different morphologies other than 1-D nanomaterials which can be efficiently explored for gas sensing properties (Table 2). Rai et al. [51] in their two step growth process fabricated ZnO nanostructures with flower-like morphologies through a hydrothermal process. For this ZnO nanorods synthesized in the initial step were treated with $[Zn(OH)_4]^{2-}$ solution. The obtained mixture was heated at 100 °C for 10 h in an autoclave. In this growth step, ZnO nanorods having diameters ranging from 250 to 500 nm and lengths from 3 to 5 µm rearrange themselves to form flower-like structures with about 5–7 µm radius. Figure 11a, b represents the FESEM images of flower-like ZnO microstructures and confirms the above said facts.

From the literature review, it was observed that 1D ZnO nanostructures with few exceptions for their NO_2 gas sensing properties operate at very high temperature starting about 200 °C which reduces their applicability at room temperature and also increases their practical cost for the gas sensing properties. Bai et al. [52] studied the growth of flower-like ZnO structures as a function of calcined temperature. ZnO nanorods formed were found to aggregate to

larger extent with increase in annealing temperature so as to give a flower-like appearance. Morphology and aspect ratio of ZnO flowers ZnO nanostructures were also found to be depending upon the extent of annealing temperature.

5.3 ZnO Quantum Dots and Nanoparticles

Another approach to enhance the gas sensing properties of ZnO-based gas sensors is to reduce the particle size and to increase the surface-to-volume ratio. ZnO nanoparticles of only few nanometer crystallite size offer high density of grain boundaries and interfaces for the increased interaction of NO₂ molecules for better and quick responses in electrical resistance. Quantum-sized ZnO nanoparticles have been reported in the literature through sol-gel methods using different capping agents so as to control their growth and size [54-56]. Forleo et al. [53] obtained quantum dots with mean crystallite size of the range 2.5-4.5 nm by a simple wet chemical method at room temperature. In a similar approach, Bai et al. [54, 55] reported that the size of the ZnO quantum dots can be controlled by the nature and concentration of the capping agents. They synthesized ZnO quantum dots at room temperature by a sol-gel process using oleic acid as capping agent. Oleic acid prevents the aggregation of clusters and slows the growth rate of ZnO crystal and orients the preferential growth along [0001] direction of ZnO crystal [54, 86]. Tetraethylorthosilicate (TEOS) is also found to perform similar functions as that of oleic acids [55]. The



Fig. 10 a, b Low- and high-magnification SEM image of branched ZnO nanowires. c Very high-magnification SEM image of globular Au particle at the tip of each secondary branch of a typical branched ZnO nanowire. d EDX spectrum of nanograined ZnO nanowires. Reprinted with permission from [42]. © 2013 Elsevier B.V

alkoxyl groups of TEOS form a capping layer of silica on the surface of ZnO which have been confirmed by the presence of absorption peak at 1,000 cm⁻¹ with a small shoulder band at 890 cm⁻¹[87, 88]. Sodium dodecyl sulfate (SDS) can also be used as surface acting agent for control the growth rate of ZnO nanoparticles [56, 58]. Surface modification of by SDS molecules on the surface of ZnO can be confirmed by FT-IR analysis. For SDSmodified ZnO quantum dots, a band near 1,200 cm⁻¹ due to S=O stretching vibration of $[SO_4]^{2-}$ from the SDS molecule is observed [56, 89]. However, this band is missing in the FT-IR spectrum of non-modified ZnO nanoparticles (Fig. 12).

In another report, Rai et al. [57] synthesized ZnO nanoparticles from $Zn(OH)_2$ precursor (prepared by coprecipitation method) using trisodiumcitrate, an anionic surfactant-assisted hydrothermal process. Due to the presence of negatively charged citrate ions, there is preferential absorption of these ions on the positively charged polar planes [0001] thus decreasing the growth rate along [0001] plane by competing with $[Zn(OH)_4]^{2-}$ growth units. As reported earlier in "1-D ZnO Nanomaterials (Nanorods, Nanowires, Nanotubes, and Nanofibres)" section, cationic surfactants like CTAB direct this growth unit along positive polar planes [0001] resulting in the elongation of ZnO nanorods [41]. Figure 13 represents a comparison for growth mechanism of ZnO in the presence of anionic (trisodiumcitrate) and cationic (CTAB) surfactants. In many other reports, nonionic surfactants such as Triton X-100 are also being used as capping agents to control the growth and morphology of ZnO nanostructures [60].

5.4 ZnO Thin Films and Sheets

Two-dimensional nanostructure porous sensitive layer with comparatively larger surface-volume ratio and large number of reaction sites offers high and quick sensor response. The porosity of the surface of thin films directly influences the

Morphology	Synthetic method	Growth reagents	Substrate	Anne. temp. (°C)	Anne. time (in h)	Diameter (nm)	NGI.
Microflowers	Hydrothermal method	$Zn(NO_3)_2 \cdot 6H_2O, CTAB$	I	I	I	5-7 µm	[51]
Nanoflowers	Hydrothermal method	Zn(NO ₃) ₂ .6H ₂ O, NaOH	Ι	400	1	Several µm	[52]
				600			
				800			
Quantum dot	Wet Chemical method	Zn(CH ₃ COO) ₂ ·2H ₂ O in DMSO, (CH ₃) ₄ NOH·5H ₂ O (TMAH)	Al ₂ O ₃	I	I	2.5-4.5	[53]
Quantum dot	Sol-gel method	Zn(CH ₃ COO) ₂ ·2H ₂ O, Oleic acid	1	200	1	8	[54]
				400			
				600			
				800			
Quantum dots	Sol-gel method	Zn(CH ₃ COO) ₂ ·2H ₂ O,	Silica	200	1	5.7	[55]
		Tetraethylorthosilicate (TEOS)		400		6.9	
				600		26.1	
				800		36.8	
Quantum dot	Sol-gel method	ZnCl ₂ , SDS	I	200	.0	4.5	[56]
				400		7.4	
				600		9.5	
				800		11.3	
Nanoparticles	Hydrothermal method	Zn(NO ₃) ₂ ·6H ₂ O, trisodiumcitrate	I	I		100-150	[57]
Nanoparticles	Hydrothermal method	ZnCl ₂ , SDS, ammonium hydrogen	I	200	ю	5.5	[58]
		carbonate		400		23.2	
				600		257	
				800		270	
Necked nanoparticle	Commercial	ZnO	I	400	I	20-150	[59]
Nanoparticles	Sol-gel method	(Zn(CH ₃ COO) ₂ ·2H ₂ O), Triton X-100	I	400	I	10	[09]
Nanoporous thin films	Electrodeposition method	$ZnCl_2$	Ti	I	I	I	[61]
ZnO Coating	Atmospheric plasma-sprayed	Commercially available ZnO powders	Al_2O_3	I	I	10 µm	[62]
ZnO thin film	Sol-gel spin-coating method	Zn(CH ₃ COO) ₂ ·2H ₂ O, methanol	Glass	400	I	40-52	[63]
				500			
				600			
				700			
Hollow spheres	Template method	Zn(CH ₃ COO) ₂ .2H ₂ O, dimethylformamide (DMF), glucose and absolute ethanol	Carbon microsphere	450	7	200–400 with shell thickness of 25 nm	[64]
Nanopyramids	Non-aqueous and surfactant free hydrothermal method	Zn(CH ₃ COO) ₂ ·2H ₂ O, benzylamine	1	I	I	Hexagonal base and height of $\sim 100 \text{ nm}$	[65]
Nanotetrapods	Vapor-phase growth	Zn foil	Al_2O_3	I	I	Tetrapods ''legs'' generally	[99]



Fig. 11 FESEM images of flower-like ZnO microstructure; a low magnification, b high magnification. Reprinted with permission from [51]. © 2013 Elsevier B.V



Fig. 12 FT-IR spectra of the SDS-modified and unmodified quantum-sized ZnO nanoparticles. Reprinted with permission from [56]. 2012 Elsevier B.V

gas diffusion rate and chemisorption of oxygen and analyte gas so as to enhance the gas sensing properties [61]. Recently, Organic dye has been found to be useful for controlling the surface morphology and porosity of the ZnO thin films [61, 90–92]. The loaded dye can be removed from the deposited film by treating it with dilute base solution. A number of physical, chemical, and electrochemical methods for ZnO thin film deposition for NO₂ gas sensing applications have been reported in the literature [61–63]. Bai et al. fabricated ZnO nanoporous thin films on Ti substrates through one-step electrodeposition method using threeelectrode system constituting a reference saturated calomel electrode (SCE), Zn wire as a counter electrode, and working Ti electrode and eosin Y (EY) dye to control the morphology and porosity of the thin film [61] (Fig. 14).

Zhang et al. [62] employed atmospheric plasma spray (APS) technique for depositing ZnO gas sensing surface on alumina plate having Au electrodes and a Pt heater on its two faces using commercially available ZnO powder. Annealing temperature has a marked effect on the crystallinity and crystallite size of the ZnO-based thin films [63].



Fig. 13 Comparison of growth mechanisms of ZnO nanorods in the presence of negatively charged surfactant (trisodiumcitrate) and positively charged (CTAB) surfactants



Fig. 14 Schematic representation of the electrochemically deposited ZnO porous thin film on Ti substrate. Reprinted with permission from [61]. @ 2012 Elsevier B.V



Fig. 15 a-d SEM images of ZnO thin films annealed at 400, 500, 600, and 700 °C, respectively. Reprinted with permission from [63]. © 2011 Elsevier Ltd and Techna Group S.r.l

Crystallite size was found to increase from 40 to 52 nm as annealing temperature was increased from 400 to 700 °C for ZnO thin films deposited using sol–gel spin-coating method on glass substrate by Chougule et al. [63] (Fig. 15).

The deposition of ZnO thin films physical methods, however, suffers from major drawbacks like high-cost fabrication techniques high energy working conditions [62].

5.5 ZnO Materials with Other Morphologies

ZnO nanostructures of various other types of morphologies including hollow spheres [64], nanopyramids [65], and



Fig. 16 Growth process for the formation of ZnO nanopyramids by the solvothermal process. Reprinted with permission from [65]. \bigcirc 2012 Elsevier B.V

nanotertrapods [66] have also been utilized for gas sensing applications (Table 2). As stated earlier, the porosity of the ZnO-based gas sensors influences the gas sensing properties, the ZnO hollow sphere can be used as effective NO_2 gas sensors. Zhang et al. [64] for this approach synthesized ZnO hollow spheres templated by carbon microspheres. Ahmed et al. [65] proposed the formation of Zn(OH)₂ precursor from benzylamine and zinc acetate for the formation of ZnO nanopyramids in non-aqueous medium. Figure 16 represents the growth process related to the formation of these pyramidal structures from Zn(OH)₂ precursor.

ZnO tetrapods were grown by Calestani et al. [66] in a tubular furnace by thermal evaporation and controlled oxidation of Zn foil.

6 Fabrication of ZnO-Based Gas Sensors for NO₂

Depending upon literature reports, the fabrication of ZnObased gas sensors for NO_2 gas can be broadly classified into three categories.



Fig. 17 a Diagrammatic representation of alumina circuit board, b SEM image of alumina circuit board and c schematic illustration of doctor blading method coating ZnO sensor materials. Reprinted with permission from [37]. \odot 2012 Elsevier B.V

6.1 Direct Growth of ZnO Nanostructures on Substrate

The best studied sensors for NO₂ gas are the porous ZnObased nanostructured layers directly deposited through hydrothermal [29–32, 34, 48, 50], electrochemical deposition [33, 61], evaporation condensation [42–44], chemical bath deposition [38], electrospinning [45], sputtering [47], and atmospheric plasma spray [62] methods on the transducer surface such as alumina [31, 32, 47, 62], Si [33, 34], SiO₂ [43, 45], glass [29, 30], quartz [38], etc. Among the various morphologies of ZnO nanostructures, 1-D nanostructures have attracted much attention recently as gas sensors because of their high surface-to-volume ratio. Fabrication of 1-D nanostructures and their potential use as gas sensors is a major concern of the nanotechnology now a day. A number of methods are reported in the literature for 1-D ZnO nanostructures utilized for gas sensing application. Out of these methods, simple hydrothermal method is reported for direct growth of 1-D ZnO nanostructures on various substrates [29–32, 34, 48, 50] (Table 1).

6.2 Indirect Deposition of Grown ZnO Nanostructures on Substrate

Another approach for the fabrication of porous ZnO-based nanostructured gas sensors is pre-synthesis followed by coating of the as-synthesized ZnO nanomaterials of various morphologies such as 1-D nanorods, nanotubes, nanofibres, nanotubes, nanolines, nanowires [35–37, 39, 49], micro/ nanoflowers [51, 52], quantum dots [53], nanoparticles [57, 59], hollow spheres [64], nanopyramids [65], and nano-tetrapods [66] as thin/thick films/coatings [35–37, 39, 49, 51, 53, 57, 65, 66] on the transducer surface including alumina [35, 37, 39, 49, 51, 53, 57, 66] and SiO₂ [65].

Doctor blade method has been reported for the coating of ZnO nanomaterials on the sensor substrate in the literature by Rai et al. [37, 51, 57].

ZnO nanomaterials are mixed and grinded with α -terpinol as binder to form a paste which was coated by this method onto the cleaned alumina circuit board with cello tape on all the sides and having an interdigitated platinum electrodes to form films with thicknesses ranging from few hundred of nm to several hundred of microns. Schematic representation for the deposition of ZnO nanomaterials by doctor blade method is shown in Fig. 17. Coated thin films are annealed at high temperature for a definite time period. Au wire electrodes were connected with the help of Au or Ag paste for making sensor device [37, 51, 57]. Spin-coating technique is also reported in the literature for forming ZnO thin layers on SiO₂ substrate by Ahmed et al. [65].

As ZnO nanostructured sensors exhibit maximum response at high temperature, a resistance heater of platinum is coated by screen printing on the backside of the substrate in direct growth as well as indirect deposition methods [31, 32, 35, 36, 62].

6.3 Pelletization

Another simple approach for the fabrication of ZnO-based nanomaterials as gas sensor for NO_2 is the pressing of annealed ZnO nanomaterials into a pellet with different diameters and thicknesses under a high pressure of 7–10 MPa [40, 56, 58]. Before pressing the powders to a pellet form, suitable adhesion agent such as ethanol is mixed. Au wires are soldered on both sides of the pellet with the help of silver or gold paste to form a sensor element. The pelletbased sensor is subsequently dried and aged at high temperature to remove the adhesion agent and any adsorbates from its surface before applying for sensor application [40, 54–56, 58]. Figure 18 shows the steps for the fabrication of pelletized ZnO nanostructures for NO_2 sensing.

7 Factors Influencing Gas Sensing Properties

7.1 Effect of Calcination Temperature and Size on Gas Sensing

As stated earlier, gas response increases and resistance decreases with decreasing the ZnO crystal size, and annealing temperature plays a significant role. For obtaining optimum gas sensing properties, ZnO nanostructured materials have to be calcined at appropriate temperature. It is well-known fact that, with increasing annealing or calcination temperature, the crystallinity of the ZnO nanomaterials is improved and the extent of stoichiometric defects in the form of oxygen vacancies is increased. Greater the number of such defects better is the gas sensing response. However, a very high annealing temperature causes the agglomeration of the particles, resulting in increased crystallite size and reduced specific surface which in turn retards the gas response [93, 94].



Fig. 19 Sensor responses of ZnO nanorods calcined at 400, 600, and 800 $^{\circ}$ C temperatures. Reprinted with permission from [40]. © 2013 Elsevier B.V



Fig. 20 Gas sensing response of the ZnO-based sensor determined at different operative temperatures for different NO_2 gas concentrations. Reprinted with permission from [35]. © 2013 American Chemical Society



Fig. 18 Schematic representation of the various steps involved for the fabrication of pelletized ZnO nanostructures for NO₂ sensing

companion of pointering	Table 2 Companion of periodinances of End Dassed namedation 1002 bas sensors						
ZnO morphology	Sensor assembly	Temperature (°C)	NO ₂ conc. (ppm)	$ au_{ m res}$ (in seconds)	$ au_{ m rec}$ (in seconds)	Gas response $(R_{\rm g}/R_{\rm a})$	Ref.
Nanorods	Glass/seed layer/nanorods/Au	200	100 ≠	20	I	0.075^{α}	[29]
	Glass/Au/seed layer/nanorods	200	1	84		0.3	
Nanorods	Glass/ITO/seed layer/nanorods/Ag	200	1	182	720	1.316 ⁸ (in light)	[30]
				3-4	1,320	1.308^{δ} (in dark)	
Nanorods	Alumina/Pt/Zn thinfilm/nanorods	250	10^{\neq}	20 min	40–50 min	824^{β}	[31]
Nanorods	Alumina/Pt/seed layer/nanorods	06	1	I	I	40.9^{α}	[32]
		100				31.8^{α}	
		110				11.2^{α}	
Nanorods	Porous Si/Pt/nanorods/Pt	25-125	0.1 - 1	200–90	180-120	1.2 - 5.8	[33]
Nanorods	Si/Pt/nanorods	300	1	~ 9	~ 10	$\sim 100^{lpha}$	[34]
Nanorods	Alumina/Au/nanomaterial	350	10	I	I	~ 130	[35]
Nanoprisms							
Nanorods with nanovoids	Platinum interdigitated electrode	250	10	I	Ι	51.25	[36]
Au/ZnO nanorods	Alumina/Pt/nanorods	300	50	I	I	4.14	[37]
ZnO nanorods						10	
Hierarchical nanoclusters were built from 1D single crystal nanorods	Quartz/platinum/hierarchical nanoclusters	RT	1	I	I	1.6 (No UV) 4.1 (UV)	[38]
Ce/ZnO nanorods	Alumina/Pt/nanorods	100	2	390	I	75^{α}	[39]
Needle-like nanorods	Au electrode pallet	120	40	I	I	624	[40]
Pencil-like nanorods		400				206	
Flower-like ZnO nanorods		400				44.8	
Pencil-like nanorods	Alumina tube with Au electrodes	400	40	34 (for 5 ppm)	80 (for 5 ppm)	206	[41]
Unbranched and branched* nanowires	Sapphire substrate/Au/nanowires	300	12345	20, 17*	85, 65*	$13.97^{\alpha}, 26.09^{*\alpha}$	[42]
			2	30, 15*	100, 75*	$18.74^{\alpha}, 30.51^{*\alpha}$	
			3	$55, 04^{*}$	120, 55*	$27.49^{\alpha}, 53.85^{*\alpha}$	
			4	$35, 10^*$	$100, 45^{*}$	$36.71^{\alpha}, 77.79^{*\alpha}$	
			5	40, 12*	$100, 60^{*}$	$43.43^{\alpha}, 106.27^{*\alpha}$	
Nanowires	SiO ₂ /Si/Ti/Pt/nanowires	225	5	44	5	~ 58	[43]
Functionalized nanowires	Alumina/Pt/nanowires	190	2	Ι	I	$\sim 0.5^{lpha}$	[44]
Nanobarbed fibers	SiO ₂ /Si/nanobarbed fibers	210	0.03	90	36	1.58	[45]
Nanolines	SiO ₂ /nanoline	I	I	I	I	I	[46]
Nanobelt	Sapphire substrate/nanobelt	350	10	120 (for 5 ppm)	150 (for 5 ppm)	1.81	[47]
Nanoneedle	Glass/nanobelt thin film	200	200	41	125	64 ^β	[48]
Cacti-like structure				21	24	89 ^β	

Table 3 Comparison of performances of ZnO-based nanostructured NO2 gas sensors

continued	rphology
Table 3	ZnO moi

ZnO morphology	Sensor assembly	Temperature (°C)	NO ₂ conc. (ppm)	$\tau_{\rm res}$ (in seconds)	$\tau_{ m rec}$ (in seconds)	Gas response $(R_{ m g}/R_{ m a})$	Ref.
Nanoprisms	Alumina/Pt/nanoprism	350	1	I	I	~ 1.04	[49]
Nanofibers	Alumina/Pt/nanofibre					~ 1.25	
Nanotubes	Si/SiO ₂ /nanotubes/Au	30	500^{\neq}	I	I	1.51	[50]
Microflowers	Alumina/Pt/microflowers	300	100			12.27	[51]
Nanoflowers	Pellet with Pt electrode	150	10	8	40	55	[52]
Quantum dot	Alumina/Pt/quantum dot	200	2	I	I	$\sim 1000^{\delta}$	[53]
Quantum dot	Pellet with Ag electrode	290	5	7	35	280	[54]
Quantum dots	Pellet with Ag electrode	290	40	7 (for 5 ppm)	35 (for 5 ppm)	264	[55]
Quantum dot	Pellet with Au electrode	290	40	I	I	221.7	[56]
Nanoparticles	Alumina/Pt/nanoparticles	300	100	45	73	18	[57]
Nanoparticles	Pellet with Ag electrode	290	40	30	120	~ 230	[58]
Necked nanoparticle	Si/thin film paste/Au	200	0.2	13	10	100	[59]
Nanoparticles	Glass/thin film	200	100	6	17	$\sim 36.3^{\rm B}$	[09]
Nanoporous thin films	Ti/thin film	100	40	I	I	544.8	[61]
ZnO Coating	Alumina/Au/thin film alumina/Pt/nanofibre	300	2.42	I	I	5.3 (in dry air) 30.8 (in wet air)	[62]
ZnO thin film	Glass substrate/thin film	200	100	6.72	52.62	37.2 ^β	[63]
Hollow spheres	Alumina/hollow sphere/Au	240	10	31	I	140.6	[64]
			50	19		172.8	
			100	6		286.8	
Nanopyramids	SiO ₂ /Au/nanopyramid	200	10	09	32	14.5	[65]
Nanotetrapods	Alumina/Au/nanotetrapod	300	20	I	I	20^{lpha}	[99]
* Represents the parameters for branched nanowires $\alpha = (R_{\rm g} - R_{\rm a})/R_{\rm a}, \ \beta = 100(R_{\rm g} - R_{\rm a})/R_{\rm a}, \ \delta = (I_{\rm air} - I_{\rm gas})/I_{\rm gas},$	hed nanowires $R_{\rm a}, \delta = (I_{\rm air} - I_{\rm gas})/I_{\rm gas}, \tau_{\rm res} = \text{response time}, \tau_{\rm rec} = \text{recovery time}, \neq \text{conc. in ppb}$	= recovery time	e, ≠ conc. in]	qdc			

Bai et al. [40, 52, 55] observed one such behavior for ZnO nanorods calcined at 400, 600, and 800 °C temperatures for 40 ppm NO₂ gas at 120 °C operating temperature (Fig. 19). Maximum response was observed at 600 °C as compared to 400 and 800 °C annealing temperatures.

At low annealing temperature treatment, the ZnO nanomaterials have high-specific surface area due to small crystallite size but have poor crystallinity which is an essential requirement for the sensor applications. The value of annealing temperature at which maximum response is observed for NO₂ gas further depends upon the morphology as well as on the method of synthesis of nanoparticles. Hjiri et al. [49] observed maximum response for ZnO nanofibres synthesized hydrothermally and subsequently annealed at 700 °C. ZnO quantum dots synthesized by Bai et al. [54, 55], Li et al. [56], and Fan et al. [58] annealed at 400 °C show a maximum response for 40 ppm NO₂ gas.

7.2 Effect of Operating Temperature and Concentration on Gas Sensing

From the literature study, it has been observed that there is a direct correlation between the concentration of analyte NO₂ and operating temperature for ZnO-based gas sensors. As the species are chemisorbed on the surface of ZnO nanostructures, there is expected initial increase in the extent of adsorption due to the requirement of activation energy but at relatively high operating temperature desorption of the analyte gas occurs and the sensor response decreases [40, 41]. Moreover, with increasing operational temperature, the dominant process is the adsorption of O²⁻ which also lowers the ZnO sensor response. The sensor response indicated a linearly correlation with the concentration of NO₂ at optimized value of the operative temperature [31, 32]. Ozturk et al. [29] observed that the change in the resistance increases with increasing concentration of NO₂ gas from 100 ppb⁻¹ ppm at high-temperature range of 150-200 °C for ZnO nanorods-based sensors. At low-temperature range, the recovery time of the sample is very large. Thus, under these conditions, ZnO-based sensors cannot be applied for gas sensing applications [29]. At high operating temperature, response time of the sensor is low. It is well known that ZnO is a well-known n-type semiconductor material and NO₂ is an oxidizing gas which on the surface of ZnO nanorod surface gets reduced. This results in the increase in the resistance of ZnO nanorods which increases with NO₂ concentration and subsequent adsorption. However, at very high NO₂ concentration, surface reaction rate determines the gas sensor response due to the presence of insufficient adsorption sites [35, 95]. Figure 20 clearly demonstrates the variations of sensor response as a function of concentration of NO₂ and operating temperature.



Fig. 21 Physically and chemically adsorbed water molecules on the surface of ZnO nanosheets. Reprinted with permission from [104]. © 2013 Elsevier B.V

One of the major drawbacks of the reported ZnO-based gas sensors is the high operative temperature which is the main obstacle for their commercial applications. This drawback however can be removed or reduced to some extent by utilizing highly porous, with large specific surface area of ZnO nanosensors. Xu et al. [38] and Lu et al. [96] reported the photo-enhanced NO₂ sensing applications of ZnO-ordered nanoclusters at room temperature under UV light illumination (Table 3). Photo-generated electrons present on the surface of the ZnO sensor under UV light illumination symbiotically reduce the adsorbed NO₂ gas, enhancing the resistance and hence the sensor response [96].

7.3 Effect of Relative Humidity

Another factor which affects the sensing performance of the ZnO nanostructure-based sensors is the environmental humidity. Physisorbed and chemisorbed water molecules are as shown in Fig. 21 form OH^- ions at above 200 °C which may remain attached to the ZnO sensor surface even up to 400 °C [97, 102–104]. Adsorbed water on the surface of ZnO lowers the gas response of due to reaction with surface oxygen thereby decreasing the baseline resistance and hence gas response [98, 99].

In relatively high humidity, adsorption of water molecules also prevents the chemisorption of oxygen on the surface of the sensor which is the prime requirement for the sensor response. This adsorbed water layer may act as a barrier between the ZnO sensor surface and the NO₂ gas [97]. Deterioration of the gas response of ZnO gas sensors may further be increased due to the formation of chemisorbed OH⁻ from adsorbed water molecules on the surface [100, 101]. However, these ions can be desorbed from the surface by operating the sensor applications at high temperature [99]. In nutshell, the adsorption of water significantly lowers the gas response and repeatability of ZnO gas sensors. However, humidity can be removed from the sensor surface by high-temperature treatment. Table 3 clearly shows that maximum response is observed at temperature \geq 400 °C for maximum reports irrespective to the morphology, size, and method of synthesis of ZnO and sensor fabrication technique.

8 Conclusion

In summary, ZnO nanomaterials can be efficiently utilized as sensors for NO₂ gas. ZnO nanorods and related 1-D materials, porous ZnO nanosheets and thin films with greater specific surface area, charge confinement ability and more reaction sites usually show better gas sensing properties than ZnO nanomaterials with other morphologies. Adsorption of the NO₂ gas on the surface of the ZnO nanostructures is reduced by the transfer of the electrons from the conduction band which increases the resistance and increases the gas sensor response. The five parameters viz. gas response, recovery time, response time, selectivity, and detection limit depend upon the morphology, size, and surface area of the ZnO nanomaterials, the interaction between the gas and the sensor, concentration of NO₂ gas, the operating temperature, etc. High-temperature annealing of the ZnO nanostructures results in the agglomeration into large entities. Due to this surface areas and hence gas sensing properties are reduced. It is mandatory to mention that 1D-ZnO nanomaterials provide a prospective base due to their crystallographic planes for their applications as durable conductometric gas sensors. Another factor which affects the sensing performance of the ZnO nanostructurebased sensors is the environmental humidity. Physisorbed and chemisorbed water molecules significantly lowers the gas response and repeatability of ZnO gas sensors. The major drawbacks and obstacle for the commercial applications of the reported ZnO-based gas sensors are the high operative temperature conditions and repeatability. The future research thus should focus to remove or reduce these limitations by synthesizing highly porous materials with large surface-to-volume ratio, optimization of the annealing and operating temperature, and using suitable additives like Pd, Pt, In, Cu, Nb, Mn, Ce, Si or other metal oxides so as to improve the gas response of ZnO-based nanosensors.

Acknowledgments This work was supported by NSTIP strategic technologies programs, number (12-NAN2551-02) in the Kingdom of Saudi Arabia.

Open Access This article is distributed under the terms of the Creative Commons Attribution License which permits any use, distribution, and reproduction in any medium, provided the original author(s) and the source are credited.

117

References

- Q. Qi, T. Zhang, S. Wang, X. Zheng, Humidity sensing properties of KCl-doped ZnO nanofibers with super-rapid response and recovery. Sens. Actuators B: Chem. 137(2), 649–655 (2009). doi:10.1016/j.snb.2009.01.042
- P. Ivanov, E. Llobet, X. Vilanova, J. Brezmes, J. Hubalek, X. Correig, Development of high gas response ethanol gas sensors based on Pt-doped SnO₂ surfaces. Sens. Actuators B: Chem. 99(2–3), 201–206 (2004). doi:10.1016/j.snb.2003.11.012
- R.L. Vander Wal, G.W. Hunter, J.C. Xu, M.J. Kulis, G.M. Berger, T.M. Ticich, Metal oxide nanostructure and gas-sensing performance. Sens. Actuators B: Chem. 138(1), 113–119 (2009). doi:10.1016/j.snb.2009.02.020
- F. Rock, N. Barsan, U. Weimar, Electronic nose: current status and future trends. Chem. Rev. 108(2), 705–725 (2008). doi:10. 1021/cr068121q
- X. Zhou, J. Zhang, T. Jiang, X. Wang, Z. Zhu, Humidity detection by nanostructured ZnO: a wireless quartz crystal microbalance investigation. Sens. Actuators A: Physical 135(1), 209–214 (2007). doi:10.1016/j.sna.2006.07.001
- C. Wagner, K. Hauffe, The stationary state of catalysts in homogeneous reactions. Ztschr. Elektrochem. 33, 172 (1938)
- T. Seiyama, A. Kato, K. Fujiishi, M. Nagatani, A new detector for gaseous components using semiconductive thin film. Anal. Chem. 34(11), 1502–1503 (1962). doi:10.1021/ac60191a001
- L. Liao, H.B. Lu, J.C. Li, H. He, D.F. Wang, D.J. Fu, C. Liu, Size dependence of gas response of ZnO nanorods. J. Phys. Chem. 111(5), 1900–1903 (2007). doi:10.1021/jp065963k
- J.-T. Hsueh, C.-L. Hsu, S.-J. Chang, I.-C. Chen, Laterally grown ZnO nanowire ethanol gas sensors. Sens. Actuators B: Chem. 126(2), 473–477 (2007). doi:10.1016/j.snb.2007.03.034
- P.-S. Cho, K.-W. Kim, J.-H. Lee, NO₂ sensing characteristics of ZnO nanorods prepared by hydrothermal method. J. Electroceram. 17(2–4), 975–978 (2006). doi:10.1007/s10832-006-8146-7
- P. Feng, Q. Wan, T.H. Wang, Contact-controlled sensing properties of flowerlike ZnO nanostructure. Appl. Phys. Lett. 87, 213111 (2005). doi:10.1063/1.2135391
- Y.-J. Choi, I.-S. Hwang, J.-G. Park, K.-J. Choi, J.-H. Park, J.-H. Lee, Novel fabrication of a SnO₂ nanowire gas sensor with high gas response. Nanotechnology **19**, 095508 (2008). doi:10.1088/ 0957-4484/19/9/095508
- S. Shi, Y. Liu, Y. Chen, J. Zhang, Y. Wang, T. Wang, Ultrahigh ethanol response of SnO₂ nanorods at low working temperature arising from La₂O₃ loading. Sens. Actuators B: Chem. **140**(2), 426–431 (2009). doi:10.1016/j.snb.2009.04.058
- 14. J.-K. Choi, I.-S. Hwang, S.-J. Kim, J.-S. Park, S.-S. Park, U. Jeong, Y.C. Kang, J.-H. Lee, Design of selective gas sensors using electrospun Pd-doped SnO₂ hollow nanofibers. Sens. Actuators B: Chem. **150**(1), 191–199 (2010). doi:10.1016/j.snb. 2010.07.013
- C.S. Rout, G.U. Kulkarni, C.N.R. Rao, Room temperature hydrogen and hydrocarbon sensors based on single nanowires of metal oxides. J. Phys. D-Appl. Phys. 40(9), 2777–2782 (2007). doi:10.1088/0022-3727/40/9/016
- H.G. Choi, Y.H. Jung, D.K. Kim, Solvothermal synthesis of tungsten oxide nanorod/nanowire/nanosheet. J. Am. Ceram. Soc. 88(6), 1684–1686 (2005). doi:10.1111/j.1551-2916.2005.00341.x
- N.V. Hieu, V.V. Quang, N.D. Ho, D. Kim, Preparing large-scale WO₃ nanowire-like structure for high gas response NH₃ gas sensor through a simple route. Curr. Appl. Phys. **11**(3), 657–661 (2011). doi:10.1016/j.cap.2010.11.002
- 18. X. Gou, G. Wang, J. Yang, J. Park, D. Wexler, Chemical synthesis, characterisation and gas sensing performance of copper

oxide nanoribbons. J. Mater. Chem. **18**, 965–969 (2008). doi:10. 1039/b716745h

- H. Kim, C. Jin, S. Park, S. Kim, C. Lee, H₂S gas sensing properties of bare and Pd-functionalized CuO nanorods. Sens. Actuators B: Chem. 161(1), 594–599 (2012). doi:10.1016/j.snb. 2011.11.006
- F.-N. Meng, X.-P. Di, H.-W. Dong, Y. Zhang, C.-L. Zhu, C. Li, Y.-J. Chen, Ppb H₂S gas sensing characteristics of Cu₂O/CuO sub-microspheres at low-temperature. Sens. Actuators B: Chem. 182, 197–204 (2013). doi:10.1016/j.snb.2013.02.112
- 21. Q. Hao, L. Li, X. Yin, S. Liu, Q. Li, T. Wang, Anomalous conductivity-type transition sensing behaviors of n-type porous α -Fe₂O₃ nanostructures toward H₂S. Mater. Sci. Eng. B **176**(7), 600–605 (2011). doi:10.1016/j.mseb.2011.02.002
- W. Zheng, X. Lu, W. Wang, Z. Li, H. Zhang, Y. Wang, Z. Wang, C. Wang, A highly sensitive and fast-responding sensor based on electrospun In₂O₃ nanofibers. Sens. Actuators B: Chem. **142**(1), 61–65 (2009). doi:10.1016/j.snb.2009.07.031
- W. Zheng, X. Lu, W. Wang, Z. Li, H. Zhang, Z. Wang, X. Xu, S. Li, C. Wang, Assembly of Pt nanoparticles on electrospun In₂O₃ nanofibers for H₂S detection. J. Colloid Interface Sci. 338(2), 366–370 (2009). doi:10.1016/j.jcis.2009.06.041
- N. Singh, R.K. Gupta, P.S. Lee, Gold-nanoparticle-functionalized In₂O₃ nanowires as CO gas sensors with a significant enhancement in response. Appl. Mater. Interfaces 3(7), 2246–2252 (2011). doi:10.1021/am101259t
- 25. J. Xu, Y. Chen, J. Shen, Ethanol sensor based on hexagonal indium oxide nanorods prepared by solvothermal methods. Mater. Lett. 62(8–9), 1363–1365 (2008). doi:10.1016/j.matlet. 2007.08.054
- 26. Z. Guo, M. Li, J. Liu, Highly porous CdO nanowires: preparation based on hydroxy- and carbonate-containing cadmium compound precursor nanowires, gas sensing and optical properties. Nanotechnology **19**, 245611 (2008). doi:10.1088/0957-4484/19/24/245611
- Z. Liu, T. Yamazaki, Y. Shen, T. Kikuta, N. Nakatani, T. Kawabat, Room temperature gas sensing of p-type TeO₂ nanowires. Appl. Phys. Lett. **90**(17), 173119 (2007). doi:10.1063/1. 2732818
- M.B. Rahmani, S. Keshmiri, J. Yu, A. Sadek, L. Al-Mashat, A. Moafi, K. Latham, Y. Li, W. Wlodarski, K. Kalantar-Zadeh, Gas sensing properties of thermally evaporated lamellar MoO₃. Sens. Actuators B: Chem. **145**(1), 13–19 (2010). doi:10.1016/j.snb. 2009.11.007
- S. Öztürk, N. Kılınç, Z.Z. Öztürk, Fabrication of ZnO nanorods for NO₂ sensor applications: effect of dimensions and electrode position. J. Alloys Compd. 581, 196–201 (2013). doi:10.1016/j. jallcom.2013.07.063
- Y. Sahin, S. Öztürk, N. Kılınc, A. Kösemen, M. Erkovane, Z.Z. Öztürk, Electrical conduction and NO₂ gas sensing properties of ZnO nanorods. Appl. Surf. Sci. **303**, 90–96 (2014). doi:10.1016/ j.apsusc.2014.02.083
- 31. E. Oh, H.-Y. Choi, S.-H. Jung, S. Cho, J.C. Kim, K.-H. Lee, S.-W. Kang, J. Kim, J.-Y. Yun, S.-H. Jeong, High-performance NO₂ gas sensor based on ZnO nanorod grown by ultrasonic irradiation. Sens. Actuators B: Chem. **141**(1), 239–243 (2009). doi:10.1016/j.snb.2009.06.031
- 32. F.-T. Liu, S.-F. Gao, S.-K. Pei, S.-C. Tseng, C.-H.J. Liu, ZnO nanorod gas sensor for NO₂ detection. J. Taiwan Inst. Chem. E. 40(5), 528–532 (2009). doi:10.1016/j.jtice.2009.03.008
- 33. D. Yan, M. Hu, S. Li, J. Liang, Y. Wu, S. Ma, Electrochemical deposition of ZnO nanostructures onto porous silicon and their enhanced gas sensing to NO₂ at room temperature. Electrochim. Acta **115**, 297–305 (2014). doi:10.1016/j.electacta.2013.10.007

- 34. J. Park, J.-Y. Oh, Highly-sensitive NO₂ detection of ZnO nanorods grown by a sonochemical process. J. Korean Phys. Soc. 55(3), 1119–1122 (2009)
- 35. L. Shi, A.J.T. Naik, J.B.M. Goodall, C. Tighe, R. Gruar, R. Binions, I. Parkin, J. Darr, Highly sensitive ZnO nanorod- and nanoprism-based NO₂ gas sensors: size and shape control using a continuous hydrothermal pilot plant. Langmuir **29**(33), 10603–10609 (2013). doi:10.1021/la402339m
- 36. H.V. Han, N.D. Hoa, P.V. Tong, H. Nguyen, N.V. Hieu, Singlecrystal zinc oxide nanorods with nanovoids as highly sensitive NO₂ nanosensors. Mater. Lett. **94**, 41–43 (2013). doi:10.1016/j. matlet.2012.12.006
- 37. P. Rai, Y.-S. Kim, H.-M. Song, M.-K. Song, Y.-T. Yu, The role of gold catalyst on the sensing behavior of ZnO nanorods for CO and NO₂ gases. Sens. Actuators B: Chem. **165**(1), 133–142 (2012). doi:10.1016/j.snb.2012.02.030
- 38. J. Xu, Y. Yu, X. He, J. Sun, F. Liu, G. Lu, Synthesis of hierarchical ZnO orientation-ordered film by chemical bath deposition and its gas sensing properties. Mater. Lett. 81, 145–147 (2012). doi:10.1016/j.matlet.2012.04.090
- 39. C.-J. Chang, C.-Y. Lin, J.-K. Chen, M.-H. Hsu, Ce-doped ZnO nanorods based low operation temperature NO₂ gas sensors. Ceram. Int. 40(7), 10867–10875 (2014). doi:10.1016/j.ceramint. 2014.03.080
- 40. S. Bai, L. Chen, S. Chen, R. Luo, D. Li, A. Chen, C.C. Liu, Reverse microemulsion in situ crystallizing growth of ZnO nanorods and application for NO₂ sensor. Sens. Actuators B: Chem. **190**, 760–767 (2014). doi:10.1016/j.snb.2013.09.032
- B. Shouli, L. Xin, L. Dianqing, C. Song, L. Ruixian, C. Aifan, Synthesis of ZnO nanorods and its application in NO₂ sensors. Sens. Actuators B: Chem. **153**(1), 110–116 (2011). doi:10.1016/ j.snb.2010.10.010
- 42. S. An, S. Park, H. Ko, C. Jin, W.I. Lee, C. Lee, Enhanced gas sensing properties of branched ZnO nanowires. Thin Solid Films 547, 241–245 (2013). doi:10.1016/j.tsf.2013.02.021
- M.-W. Ahn, K.-S. Park, J.-H. Heo, D.-W. Kim, K.J. Choi, J.-G. Park, On-chip fabrication of ZnO-nanowire gas sensor with high gas sensitivity. Sens. Actuators B: Chem. 138(1), 168–173 (2009). doi:10.1016/j.snb.2009.02.008
- 44. E.R. Waclawik, J. Chang, A. Ponzoni, I. Concina, D. Zappa, E. Comini, N. Motta, G. Faglia, G. Sberveglieri, Functionalised zinc oxide nanowire gas sensors: enhanced NO₂ gas sensor response by chemical modification of nanowire surfaces. Beilstein J. Nanotechnol. **3**, 368–377 (2012). doi:10.3762/bjnano.3. 43
- 45. H.-U. Lee, K. Ahn, S.-J. Lee, J.-P. Kim, H.-G. Kim, S.-Y. Jeong, C.-R. Cho, ZnO nanobarbed fibers: fabrication, sensing NO₂ gas, and their sensing mechanism. Appl. Phys. Lett. **98**(19), 193114 (2011). doi:10.1063/1.3590202
- 46. S.-W. Fan, A.K. Srivastava, V.P. Dravid, Nanopatterned polycrystalline ZnO for room temperature gas sensing. Sens. Actuators B: Chem. 144(1), 159–163 (2010). doi:10.1016/j.snb.2009. 10.054
- 47. A.Z. Sadek, W. Wlodarski, K. Kalantar-zadeh, S. Choopun, ZnO nanobelt based conductometric H₂ and NO₂ gas sensors, in *Proceedings of Sensors IEEE* (2005), pp. 1326–1329. doi:10. 1109/ICSENS.2005.1597952
- R.C. Pawar, J.-W. Lee, V.B. Patil, C.S. Lee, Synthesis of multidimensional ZnO nanostructures in aqueous medium for the application of gas sensor. Sens. Actuators B: Chem. 187, 323–330 (2013). doi:10.1016/j.snb.2012.11.100
- M. Hjiri, L.E. Mir, S.G. Leonardi, N. Donato, G. Neri, CO and NO₂ selective monitoring by ZnO-based sensors. Nanomaterials 3(3), 357–369 (2013). doi:10.3390/nano3030357

- 50. J.X. Wang, X.W. Sun, Y. Yang, C.M.L. Wu, N–P transition sensing behaviors of ZnO nanotubes exposed to NO₂ gas. Nanotechnology **20**(46), 465501 (2009). doi:10.1088/0957-4484/20/46/465501
- P. Rai, S. Raj, K.-J. Ko, K.-K. Park, Y.-T. Yu, Synthesis of flower-like ZnO microstructures for gas sensor applications. Sens. Actuators B: Chem. **178**, 107–112 (2013). doi:10.1016/j. snb.2012.12.031
- 52. S. Bai, T. Guo, D. Li, R. Luo, A. Chen, C.C. Liu, Intrinsic sensing properties of the flower-like ZnO nanostructures. Sens. Actuators B: Chem. **182**, 747–754 (2013). doi:10.1016/j.snb. 2013.03.077
- A. Forleo, L. Francioso, S. Capone, P. Siciliano, P. Lommens, Z. Hens, Synthesis and gas sensing properties of ZnO quantum dots. Sens. Actuators B: Chem. 146(1), 111–115 (2010). doi:10. 1016/j.snb.2010.02.059
- 54. B. Shouli, C. Liangyuan, H. Jingwei, L. Dianqing, L. Ruixian, C. Aifan, C.C. Liu, Synthesis of quantum size ZnO crystals and their gas sensing properties for NO₂. Sens. Actuators B: Chem. **159**(1), 97–102 (2011). doi:10.1016/j.snb.2011.06.056
- 55. S. Bai, J. Hu, D. Li, R. Luo, A. Chen, C.C. Liu, Quantum-sized ZnO nanoparticles: synthesis, characterization and sensing properties for NO₂. J. Mater. Chem. **21**, 12288–12294 (2011). doi:10.1039/c1jm11302j
- 56. D. Li, J. Hu, F. Fan, S. Bai, R. Luo, A. Chen, C.C. Liu, Quantum-sized ZnO nanoparticles synthesized in aqueous medium for toxic gases detection. J. Alloys Compd. 539, 205–209 (2012). doi:10.1016/j.jallcom.2012.05.106
- P. Rai, Y.-T. Yu, Citrate-assisted hydrothermal synthesis of single crystalline ZnO nanoparticles for gas sensor application. Sens. Actuators B: Chem. 173, 58–65 (2012). doi:10.1016/j.snb. 2012.05.068
- 58. F. Fan, Y. Feng, S. Bai, J. Feng, A. Chen, D. Li, Synthesis and gas sensing properties to NO₂ of ZNO nanoparticles. Sens. Actuators B: Chem. **185**, 377–382 (2013). doi:10.1016/j.snb. 2013.05.020
- 59. J.H. Jun, J. Yun, K. Cho, I.-S. Hwang, J.-H. Lee, S. Kim, Necked ZnO nanoparticle-based NO₂ sensors with high and fast response. Sens. Actuators B: Chem. **140**(2), 412–417 (2009). doi:10.1016/j.snb.2009.05.019
- T.V. Kolekar, S.S. Bandgar, S.S. Shirguppikar, V.S. Ganachari, Synthesis and characterization of ZnO nanoparticles for efficient gas sensors. Arch. Appl. Sci. Res. 5(6), 20–28 (2013)
- S. Bai, C. Sun, T. Guo, R. Luo, Y. Lin, A. Chen, L. Sun, J. Zhang, Low temperature electrochemical deposition of nanoporous ZnO thin films as novel NO₂ sensors. Electrochim. Acta 90, 530–534 (2013). doi:10.1016/j.electacta.2012.12.060
- 62. C. Zhang, M. Debliquy, H. Liao, Deposition and microstructure characterization of atmospheric plasma-sprayed ZnO coatings for NO₂ detection. Appl. Surf. Sci. **256**(20), 5905–5910 (2010). doi:10.1016/j.apsusc.2010.03.072
- M.A. Chougule, S. Sen, V.B. Patil, Fabrication of nanostructured ZnO thin film sensor for NO₂ monitoring. Ceram. Int. 38(4), 2685–2692 (2012). doi:10.1016/j.ceramint.2011.11.036
- 64. J. Zhang, S. Wang, Y. Wang, M. Xu, H. Xia, S. Zhang, W. Huang, X. Guo, S. Wu, ZnO hollow spheres: preparation, characterization, and gas sensing properties. Sens. Actuators B: Chem. 139(2), 411–417 (2009). doi:10.1016/j.snb.2009.03.014
- 65. M.Z. Ahmad, J. Chang, M.S. Ahmad, E.R. Waclawik, W. Wlodarski, Non-aqueous synthesis of hexagonal ZnO nanopyramids: gas sensing properties. Sens. Actuators B: Chem. 177, 286–294 (2013). doi:10.1016/j.snb.2012.11.013
- 66. D. Calestani, M. Zhaa, R. Mosca, A. Zappettini, M.C. Carotta, V. Di Natale, L. Zanotti, Growth of ZnO tetrapods for nanostructure-based gas sensors. Sens. Actuators B: Chem. 144(2), 472–478 (2010). doi:10.1016/j.snb.2009.11.009

- 67. Y. Xie, Y. He, P.L. Irwin, T. Jin, X. Shi, Antibacterial activity and mechanism of action of zinc oxide nanoparticles against *Campylobacter jejuni*. Appl. Environ. Microbiol. **77**(7), 2325–2331 (2011). doi:10.1128/AEM.02149-10
- S. Hackenberg, A. Scherzed, A. Technau, K. Froelich, R. Hagen, N. Kleinsasser, Functional responses of human adipose tissuederived mesenchymal stem cells to metal oxide nanoparticles in vitro. J. Biomed. Nanotechnol. 9(1), 86–95 (2013). doi:10. 1166/jbn.2013.1473
- 69. N. Yamazoe, New approaches for improving semiconductor gas sensors. Sens. Actuators B 5(1–4), 7–19 (1991). doi:10.1016/ 0925-4005(91)80213-4
- R. Kumar, G. Kumar, A. Umar, Zinc oxide nanomaterials for photocatalytic degradation of methyl orange: a review. Nanosci. Nanotechnol. Lett. 6(8), 631–650 (2014). doi:10.1166/nnl.2014.1879
- 71. S.A. Chevtchenko, J.C. Moore, U. Özgür, X. Gu, A.A. Baski, H. Morkoc, B. Nemeth, J.E. Nause, Comparative study of the (0001) and (000) surfaces of ZnO. Appl. Phys. Lett. 89(18), 182111 (2006). doi:10.1063/1.2378589
- 72. J. Lahiri, S. Senanayake, M. Batzill, Soft X-ray photoemission of clean and sulfur covered polar ZnO surfaces: a view of the stabilization of polar oxide surfaces. Phys. Rev. B 78, 155414 (2008). doi:10.1103/PhysRevB.78.155414
- O. Dulub, U. Diebold, G. Kresse, Novel stabilization mechanism on polar surfaces: ZnO(0001)-Zn. Phys. Rev. Lett. **90**, 016102 (2003). doi:10.1103/PhysRevLett.90.016102
- 74. P.S. Bagus, F. Illas, G. Pacchioni, F. Parmigiani, Mechanisms responsible for chemical shifts of core-level binding energies and their relationship to chemical bonding. J. Electron. Spectrosc. Relat. Phenom. **100**(1–3), 215–236 (1999). doi:10.1016/ S0368-2048(99)00048-1
- 75. G. Kresse, O. Dulub, U. Diebold, Competing stabilization mechanism of the polar ZnO (0001)-Zn surface. Phys. Rev. B 68, 245409 (2003). doi:10.1103/PhysRevB.68.245409
- 76. A. Önsten, D. Stoltz, P. Palmgren, S. Yu, M. Göthelid, U.O. Karlsson, Water adsorption on ZnO(0001): transition from triangular surface structure to a disordered hydroxyl terminated phase. J. Phys. Chem. C **114**(25), 11157–11161 (2010). doi:10. 1021/jp1004677
- 77. M. Valtiner, X. Torrelles, A. Pareek, S. Borodin, H. Gies, G. Grundmeier, In situ study of the polar ZnO(0001)-Zn surface in alkaline electrolytes. J. Phys. Chem. C 114(36), 15440–15447 (2010). doi:10.1021/jp1047024
- M. Kunat, S.G. Girol, T. Becker, U. Burghaus, C. Wöll, Stability of the polar surfaces of ZnO: a reinvestigation using He-atom scattering. Phys. Rev. B 66, 081402 (2002). doi:10.1103/Phys RevB.66.081402
- 79. B. Meyer, D. Marx, Density-functional study of the structure and stability of ZnO surfaces. Phys. Rev. B 67, 035403 (2003). doi:10.1103/PhysRevB.67.035403
- N. Han, X. Wu, L. Chai, H. Liu, Y. Chen, Counterintuitive sensing mechanism of ZnO nanoparticle based gas sensors. Sens. Actuators B: Chem. 150(1), 230–238 (2010). doi:10.1016/ j.snb.2010.07.009
- Y. Zhang, J. Xu, Q. Xiang, H. Li, Q.Y. Pan, P.C. Xu, Brush-like hierarchical ZnO nanostructures: synthesis, photoluminescence and gas sensor properties. J. Phys. Chem. C 113(9), 3430–3435 (2009). doi:10.1021/jp8092258
- C. Li, L. Li, Z. Du, H. Yu, Y. Xiang, Y. Li, Y. Cai, T. Wang, Rapid and ultrahigh ethanol sensing based on Au-coated ZnO nanorods. Nanotechnology 19(3), 035501 (2008). doi:10.1088/ 0957-4484/19/03/035501
- H. Ihokura, SnO₂-based inflammable gas sensors. Doctoral Thesis, Kyushu University (1983), pp. 52–57
- H. Mitsudo, Ceramics for gas and humidity sensors (part I)—gas sensor. Ceramics 15, 339–345 (1980)

- S. Das, S. Ghosh, Fabrication of different morphologies of ZnO superstructures in presence of synthesized ethylammonium nitrate (EAN) ionic liquid: synthesis, characterization and analysis. Dalton Trans. 42, 1645–1656 (2013). doi:10.1039/c2dt31920a
- 86. M. Yin, Y. Gu, I.L. Kuskovsky, T. Andelman, Y. Zhu, G.F. Neumark, Zinc oxide quantum rods. J. Am. Chem. Soc. **126**(20), 6206–6207 (2004). doi:10.1021/ja031696+
- L.J. Bellamy, *The Infrared Spectra of Complex Molecules*, vol. 1 (Chapman and Hall, London, 1975), p. 378
- C.H. Hung, W.T. Whang, Effect of surface stabilization of nanoparticles on luminescent characteristics in ZnO/poly(hydroxyethyl methacrylate) nanohybrid films. J. Mater. Chem. 15, 267–274 (2005). doi:10.1039/b405497k
- R. Ullah, J. Dutta, Photocatalytic degradation of organic dyes with manganese-doped ZnO nanoparticles. J. Hazard. Mater. 156(1–3), 194–200 (2008). doi:10.1016/j.jhazmat.2007.12.033
- T. Yoshida, K. Terada, D. Schlettwein, T. Oekermann, T. Sugiura, H. Minoura, Electrochemical self-assembly of nanoporous ZnO/Eosin Y thin films and their sensitized photoelectrochemical performance. Adv. Mater. **12**(16), 1214–1217 (2000). doi:10.1002/1521-4095(200008)12::16<1214:AID-ADMA1214>3.0.CO;2-Z
- 91. T. Yoshida, J. Zhang, D. Komatsu, S. Sawatani, H. Minoura, Th. Pauporté, D. Lincot, T. Oekermann, L. Peter, D. Schlettwain, H. Tada, D. Wöhrle, K. Funabiki, M. Matsui, H. Miura, H. Yanagi, Electrodeposition of inorganic/organic hybrid thin films. Adv. Funct. Mater. 19(1), 17–43 (2009). doi:10.1002/adfm.200700188
- P. Liu, W.Y. Li, J.B. Zhang, Electrodeposition and photocatalytic selectivity of ZnO/methyl blue hybrid thin films. J. Phys. Chem. C 113(32), 14279–14282 (2009). doi:10.1021/jp903896j
- 93. J.H. Yang, X.Y. Liu, L.L. Yang, Y.X. Wang, Y.J. Zhang, J.H. Lang, Effect of annealing temperature on the structure and optical properties of ZnO nanoparticles. J. Alloys Compd. 477(1–2), 632–635 (2009). doi:10.1016/j.jallcom.2008.10.135
- 94. S.D. Shinde, G.E. Patil, D.D. Kajale, V.G. Wagh, V.B. Gaikwad, G.H. Jain, Effect of annealing on gas sensing performance of nanostructured ZnO thick film resistors. Int. J. Smart Sens. Intell. Syst. 5, 277–294 (2012)

- 95. W.-J. Li, E.-W. Shi, W.-Z. Zhong, Z.-W. Yin, Growth mechanism and growth habit of oxide crystals. J. Cryst. Growth 203(1–2), 186–196 (1999). doi:10.1016/S0022-0248(99)00076-7
- 96. G. Lu, J. Xu, J. Sun, Y. Yu, Y. Zhang, F. Liu, UV-enhanced room temperature NO₂ sensor using ZnO nanorods modified with SnO₂ nanoparticles. Sens. Actuators B: Chem. **162**(1), 82–88 (2012). doi:10.1016/j.snb.2011.12.039
- 97. C. Wang, L. Yin, L. Zhang, D. Xiang, R. Gao, Metal oxide gas sensors: gas response and influencing factors. Sensors 10(3), 2088–2106 (2010). doi:10.3390/s100302088
- 98. Q. Qi, T. Zhang, X. Zheng, H. Fan, L. Liu, R. Wang, Y. Zeng, Electrical Response of Sm₂O₃-doped SnO₂ to C₂H₂ and effect of humidity interference. Sens. Actuators B: Chem. **134**(1), 36–42 (2008). doi:10.1016/j.snb.2008.04.011
- 99. J. Gong, Q. Chen, M. Lian, N. Liu, R.G. Stevenson, F. Adamic, Micromachined nanocrystalline silver doped SnO₂ H₂S sensor. Sens. Actuators B: Chem. **114**(1), 32–39 (2006). doi:10.1016/j. snb.2005.04.035
- E. Traversa, Ceramic sensors for humidity detection: the stateof-the-art and future developments. Sens. Actuators B: Chem. 23(2–3), 135–156 (1995). doi:10.1016/0925-4005(94)01268-M
- 101. Z. Bai, C. Xie, M. Hu, S. Zhang, D. Zeng, Effect of humidity on the gas sensing property of the tetrapod-shaped ZnO nanopowder sensor. Mater. Sci. Eng. B 149(1), 12–17 (2008). doi:10. 1016/j.mseb.2007.11.020
- 102. R.G. Pavelko, H. Daly, C. Hardacre, A.A. Vasiliev, E. Llobet, Interaction of water, hydrogen and their mixtures with SnO₂ based materials: the role of surface hydroxyl groups in detection mechanisms. Phys. Chem. Chem. Phys. **12**(11), 2639–2647 (2010). doi:10.1039/b921665k
- 103. A. Stanoiu, C.E. Simion, S. Somacescu, NO₂ sensing mechanism of ZnO–Eu₂O₃ binary oxide under humid air conditions. Sens. Actuators B: Chem. **186**, 687–694 (2013). doi:10.1016/j. snb.2013.06.083
- 104. F.-S. Tsai, S.-J. Wang, Enhanced sensing performance of relative humidity sensors using laterally grown ZnO nanosheets. Sens. Actuators B: Chem. **193**, 280–287 (2014). doi:10.1016/j. snb.2013.11.069